

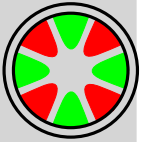
Practical Electron Optics of EEL Spectrometers & Imaging Energy Filters

Heiko Müller

CEOS GmbH, Englerstr. 28, D-69126 Heidelberg, Germany

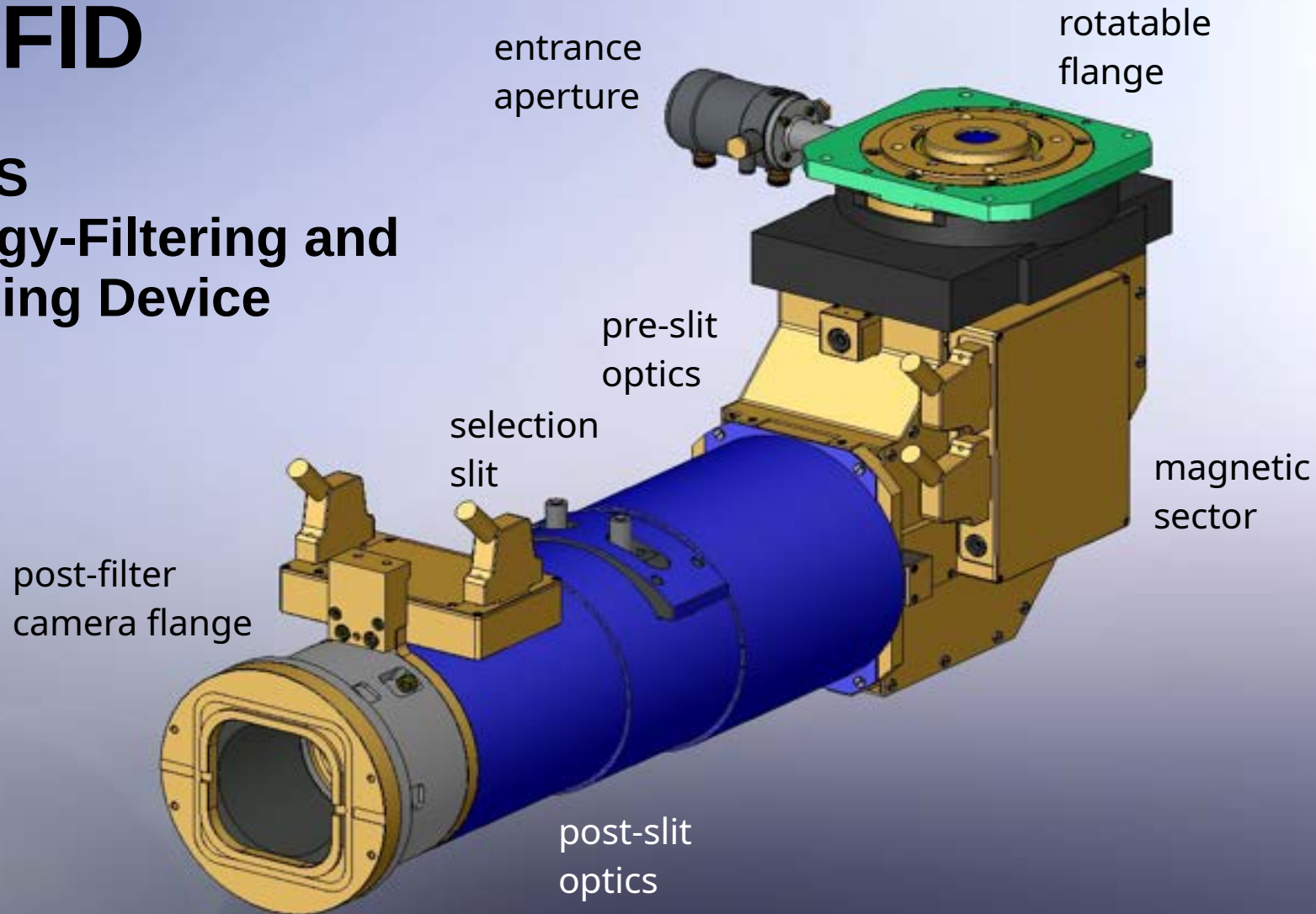
Imaging Energy Filters today are versatile tools for:

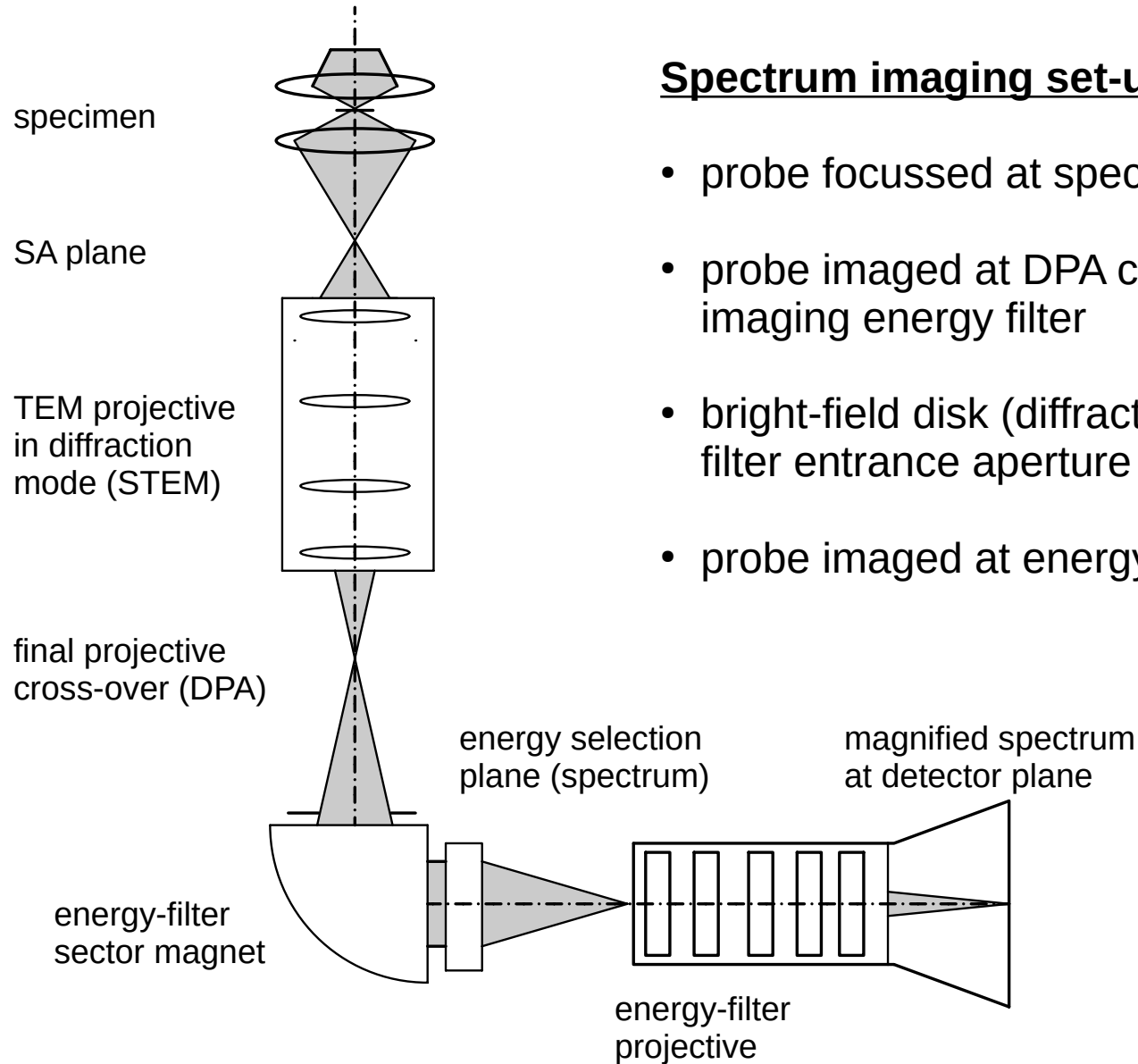
- Electron Energy Loss Spectroscopy in (S)TEM mode
- Zero-Loss Filtering in life science
- Energy-Filtered Imaging (Electron Spectroscopic Imaging)
- Energy-Filtered Diffraction
- STEM Spectrum Imaging (EELS Data Cube)
- Momentum-Resolved Spectroscopy (ω q-EELS)
- Energy-Filtered 4D STEM (STEM Data Tesseract)
- Event-based and correlated data acquisition techniques



CEFID

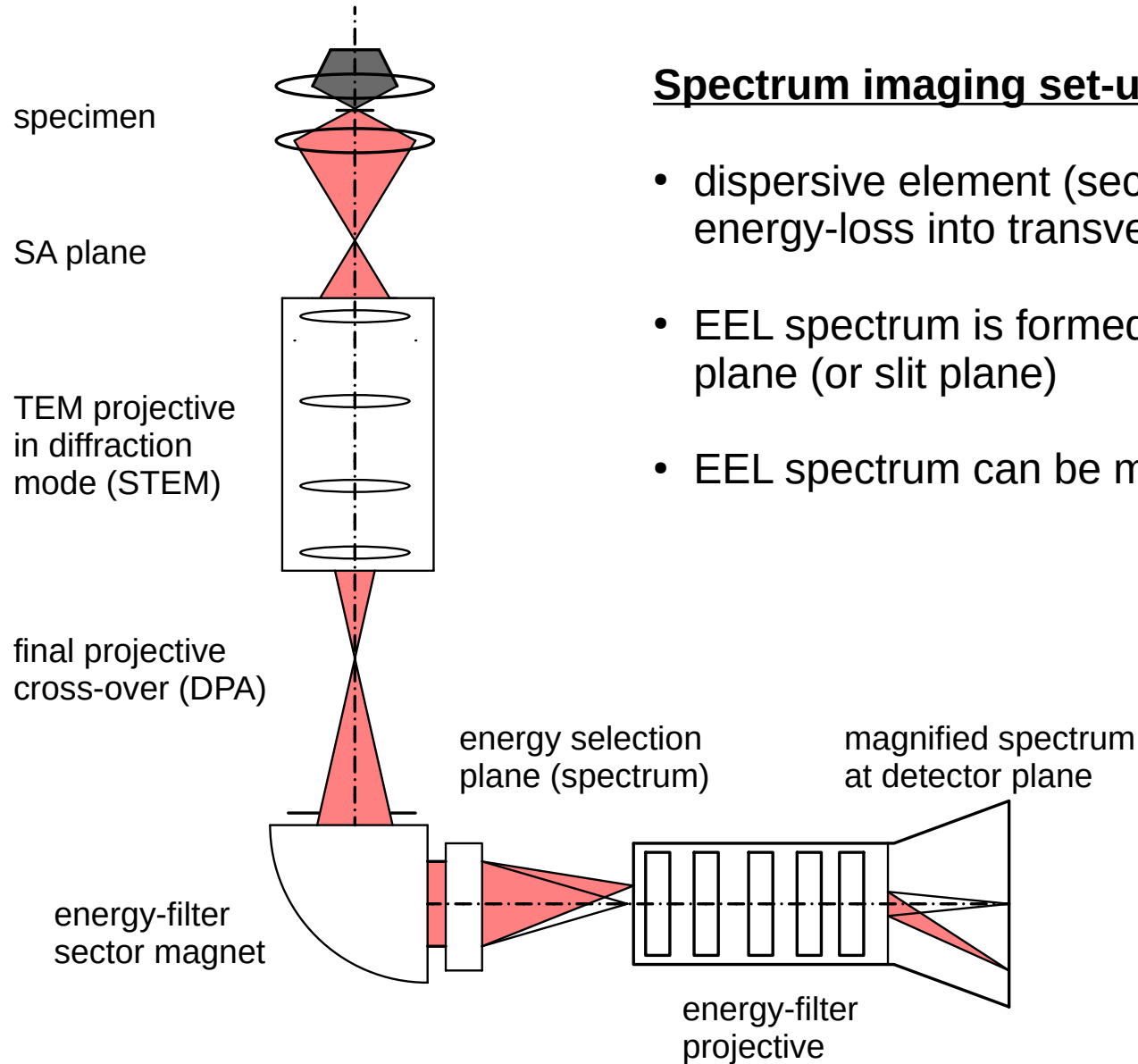
CEOS Energy-Filtering and Imaging Device





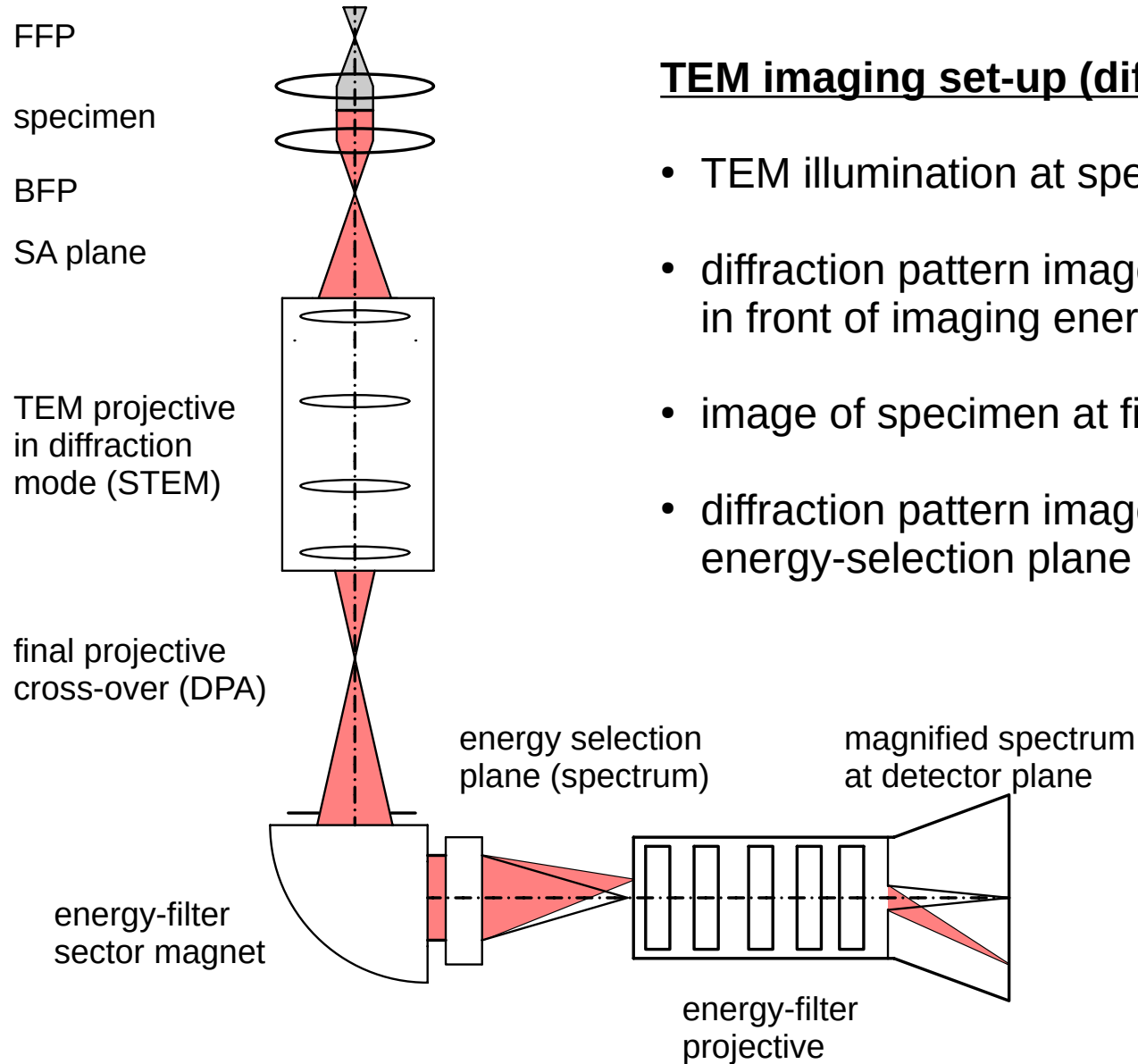
Spectrum imaging set-up (image coupled):

- probe focussed at specimen (STEM mode)
- probe imaged at DPA cross-over in front of imaging energy filter
- bright-field disk (diffraction pattern) at filter entrance aperture
- probe imaged at energy-selection plane



Spectrum imaging set-up (image coupled):

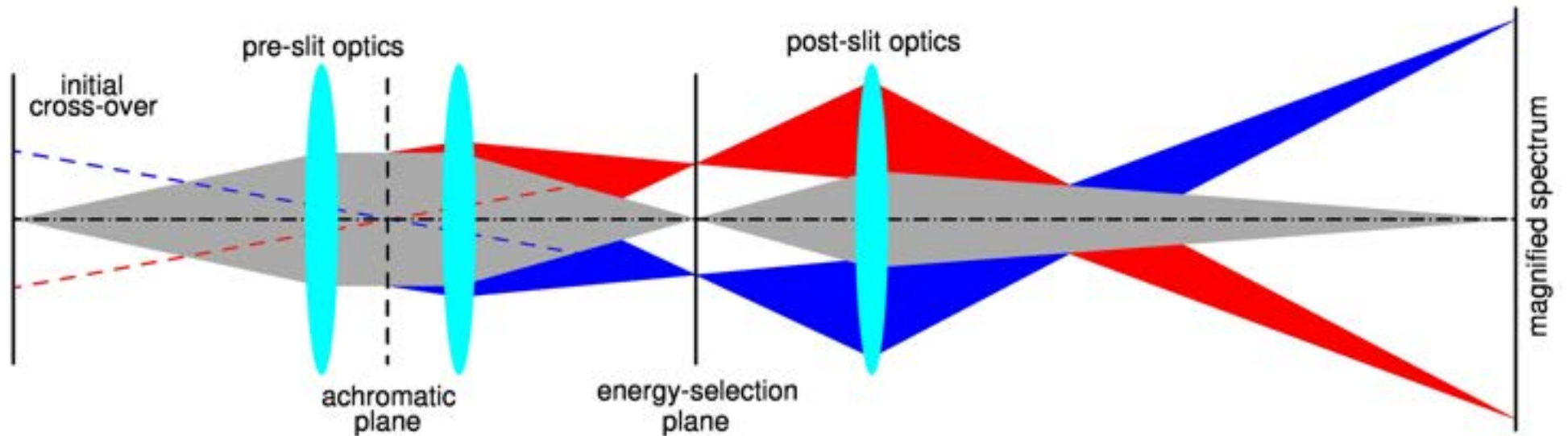
- dispersive element (sector magnet) translates energy-loss into transversal displacement
- EEL spectrum is formed at the energy selection plane (or slit plane)
- EEL spectrum can be magnified onto the detector



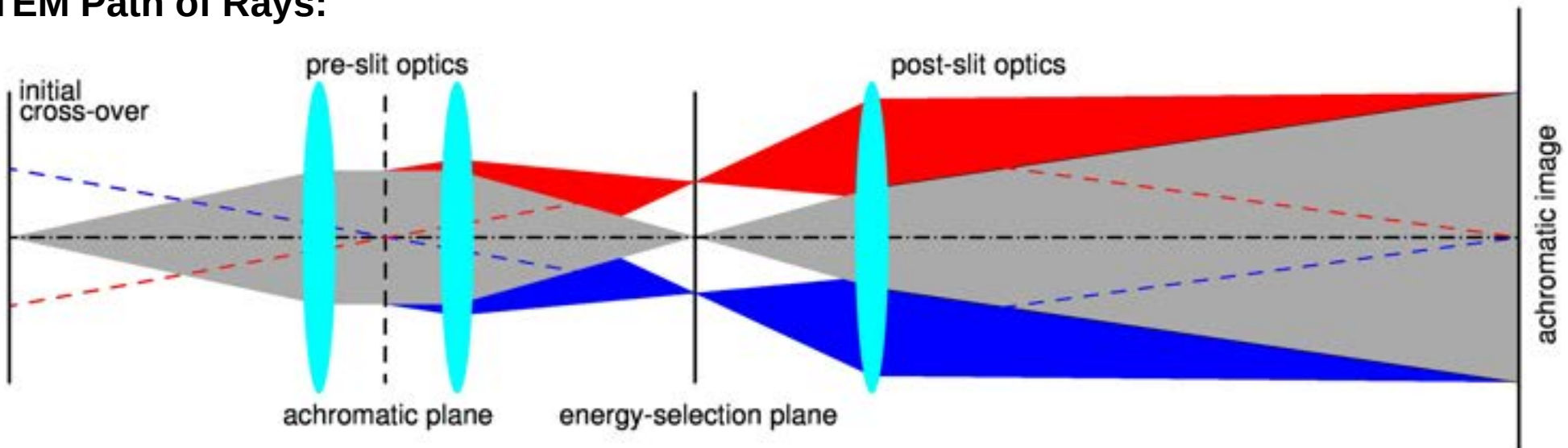
TEM imaging set-up (diffraction coupled):

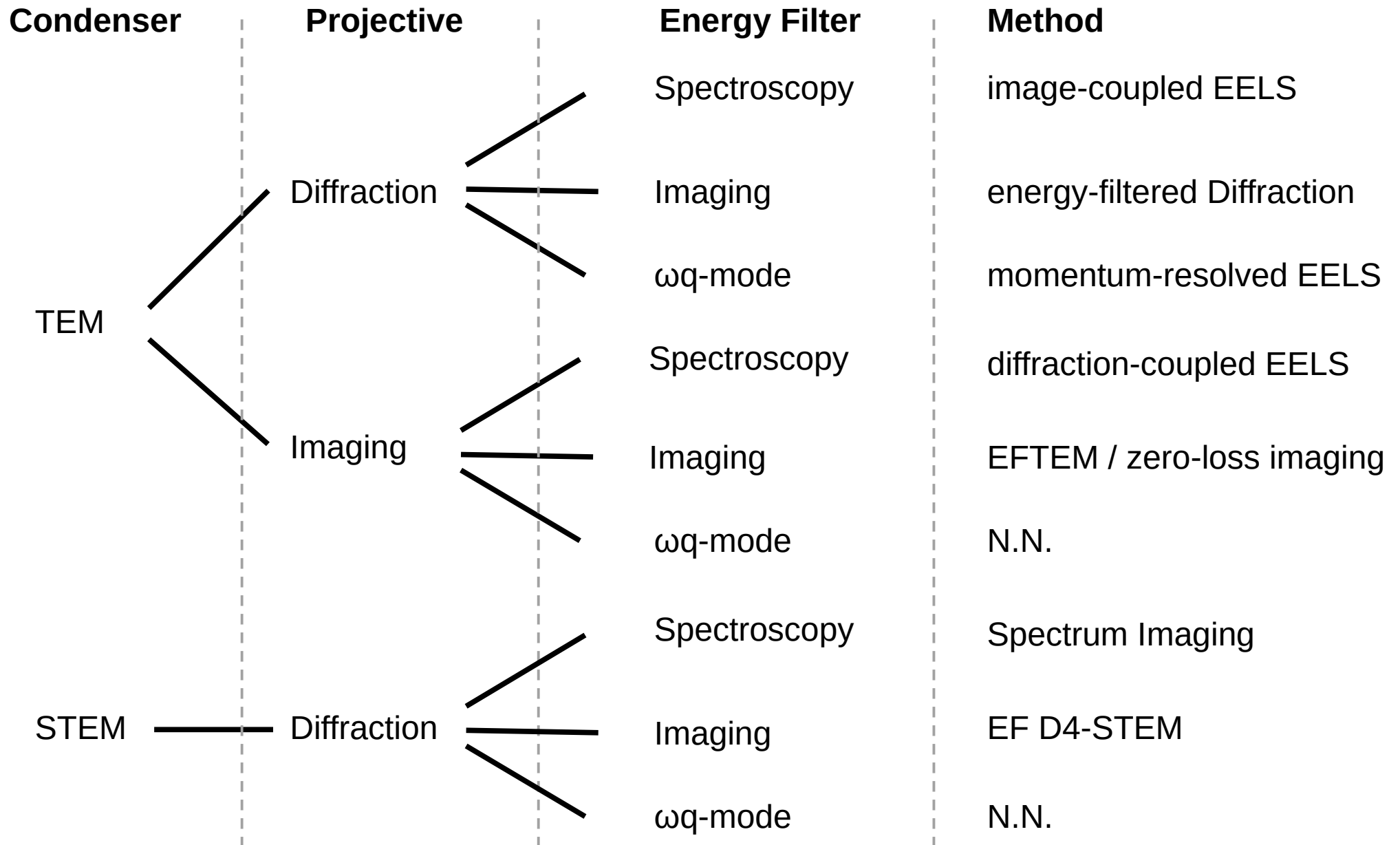
- TEM illumination at specimen
- diffraction pattern imaged at DPA cross-over in front of imaging energy filter
- image of specimen at filter entrance aperture
- diffraction pattern imaged at energy-selection plane

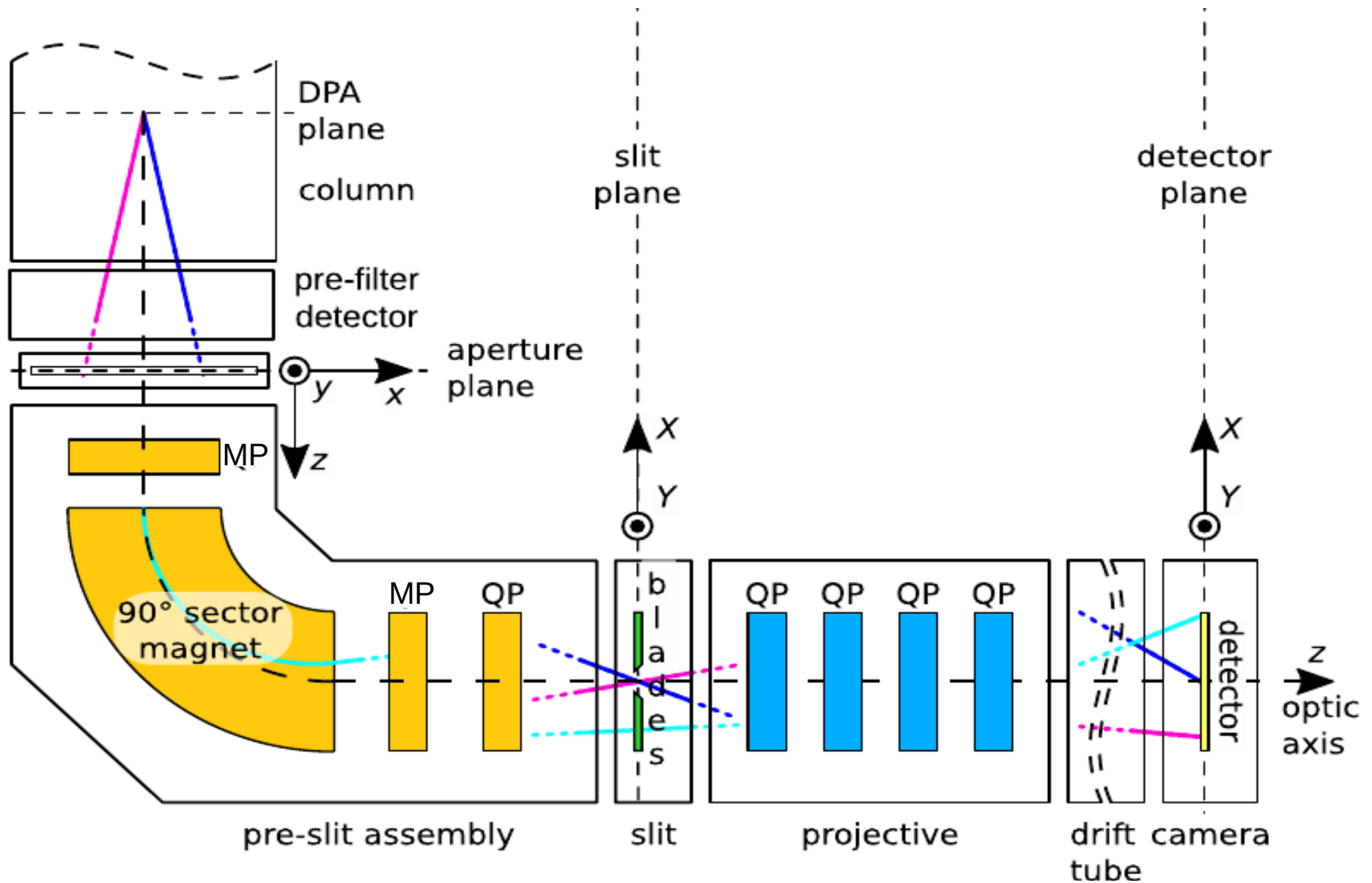
EELS Path of Rays:



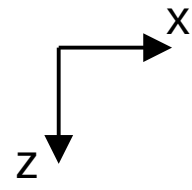
EFTEM Path of Rays:

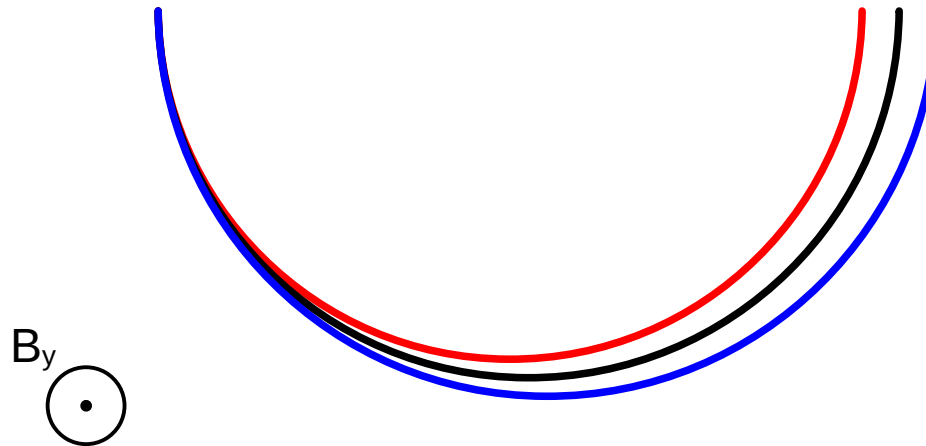






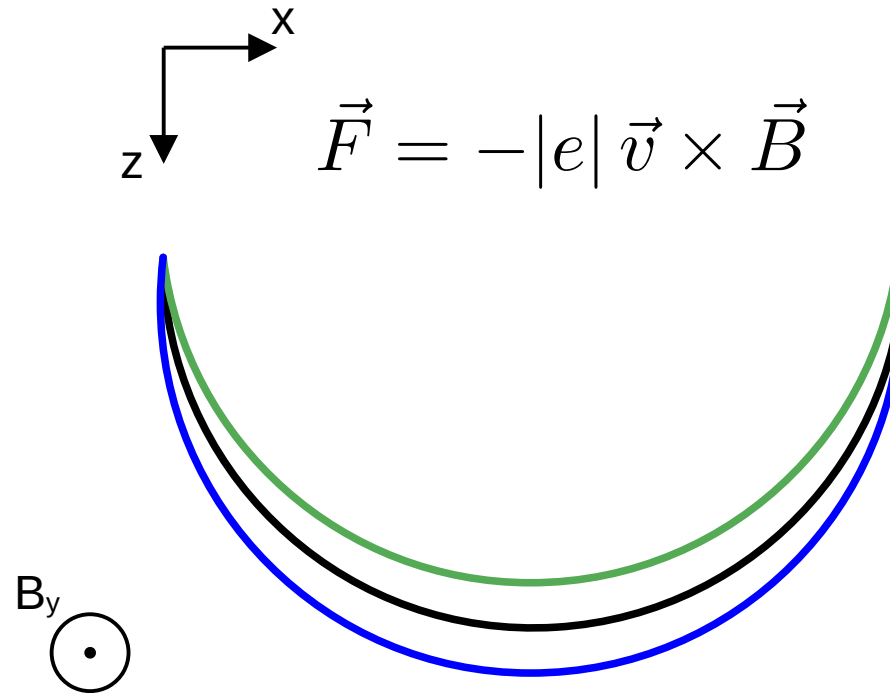
Electrons traveling in homogenous magnetic field:


$$\vec{F} = -|e| \vec{v} \times \vec{B}$$



- electrons travel on circles
- different energies travel on different radii
- deflection cause energy dispersion

Electrons traveling in homogenous magnetic field:



- electrons travel on circles
- different energies travel on different radii
- deflection causes energy dispersion
- electrons in xz-section are focussed toward optic axis
- focussing in $\pm x$ is asymmetric \Rightarrow second-order aberrations

Optics of a homogeneous sector magnet:

α, β : coordinates in filter entrance aperture $\kappa = \frac{\Delta E}{E_0}$: chromatic parameter

$$x(\alpha, \beta, \kappa) = \alpha x_\alpha + \kappa x_\kappa$$

$$y(\alpha, \beta, \kappa) = \beta y_\beta$$

$$U^* = U(1 + \varepsilon U) \quad \varepsilon = \frac{|e|\hbar^2}{2m_e c^2} \quad \Lambda = \frac{1 + 2\varepsilon U}{1 + \varepsilon U}$$

$$x'' + \frac{1}{R^2} x = -\frac{\Lambda}{2R} \frac{\Delta E}{E_0} \quad \frac{1}{R} = -\sqrt{\frac{|e|\hbar^2}{2m_e U^*}} \Psi_{1s}$$

Optics of a homogeneous sector magnet:

$$x'' + \frac{1}{R^2} x = -\frac{\Lambda}{2R} \frac{\Delta E}{E_0}$$

$$\frac{1}{R} = -\sqrt{\frac{|e|\hbar}{2m_e U^*}} \Psi_{1s}$$

Dispersion ray:

$$x_\kappa = -\frac{\Lambda R}{2} \left(1 - \cos \left(\frac{z}{R} \right) \right)$$

$$x'_\kappa = -\frac{\Lambda}{2} \sin \left(\frac{z}{R} \right)$$

for 300kV:

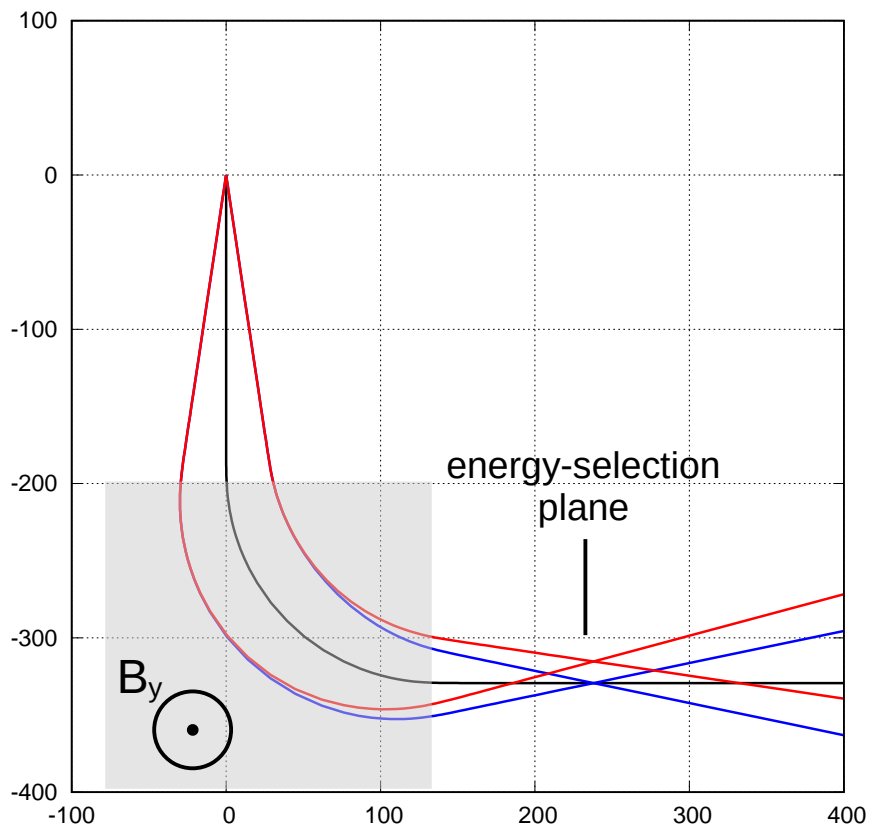
$$\frac{d\vartheta}{dE} = -\frac{\Lambda}{2E} \approx 2.0 \frac{\mu\text{rad}}{\text{eV}}$$

for 60kV:

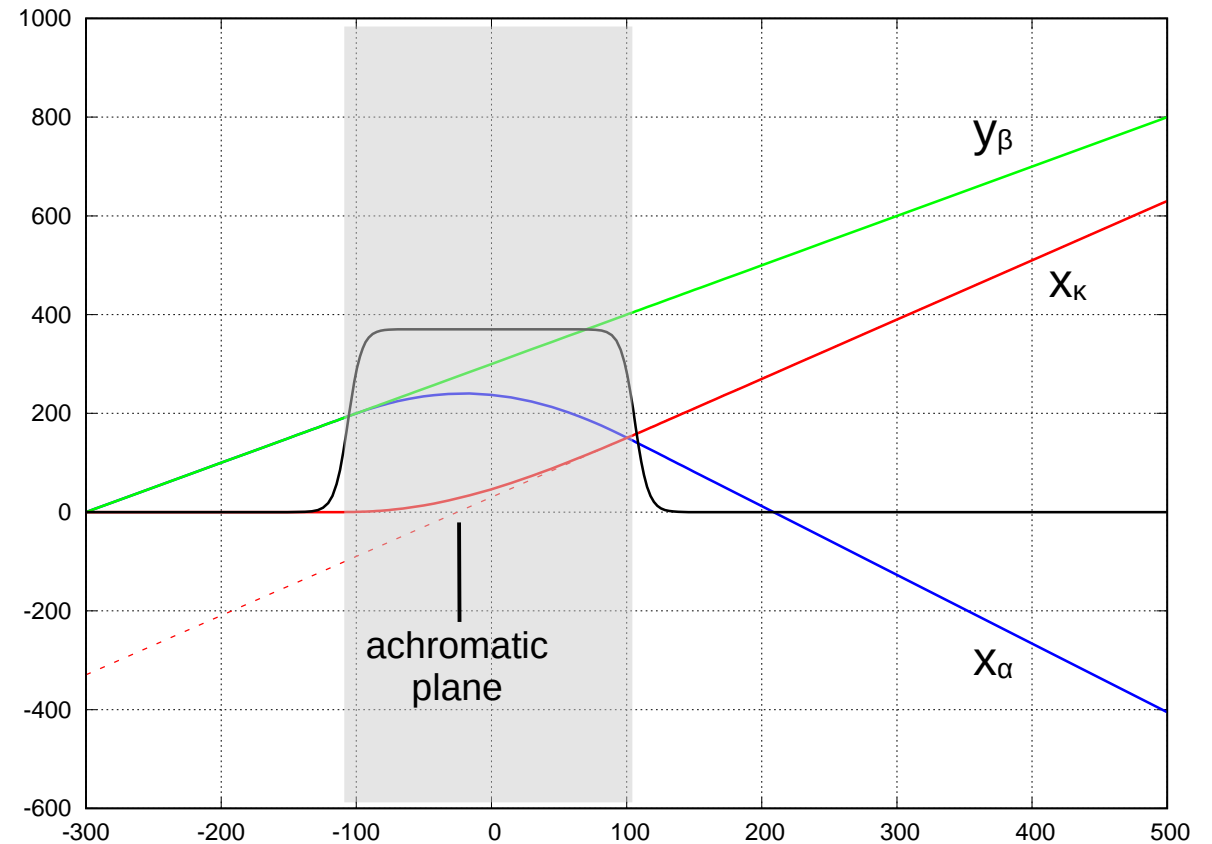
$$\frac{d\vartheta}{dE} = -\frac{\Lambda}{2E} \approx 8.8 \frac{\mu\text{rad}}{\text{eV}}$$

Pre-slit raypath of simple 90° sector magnet:

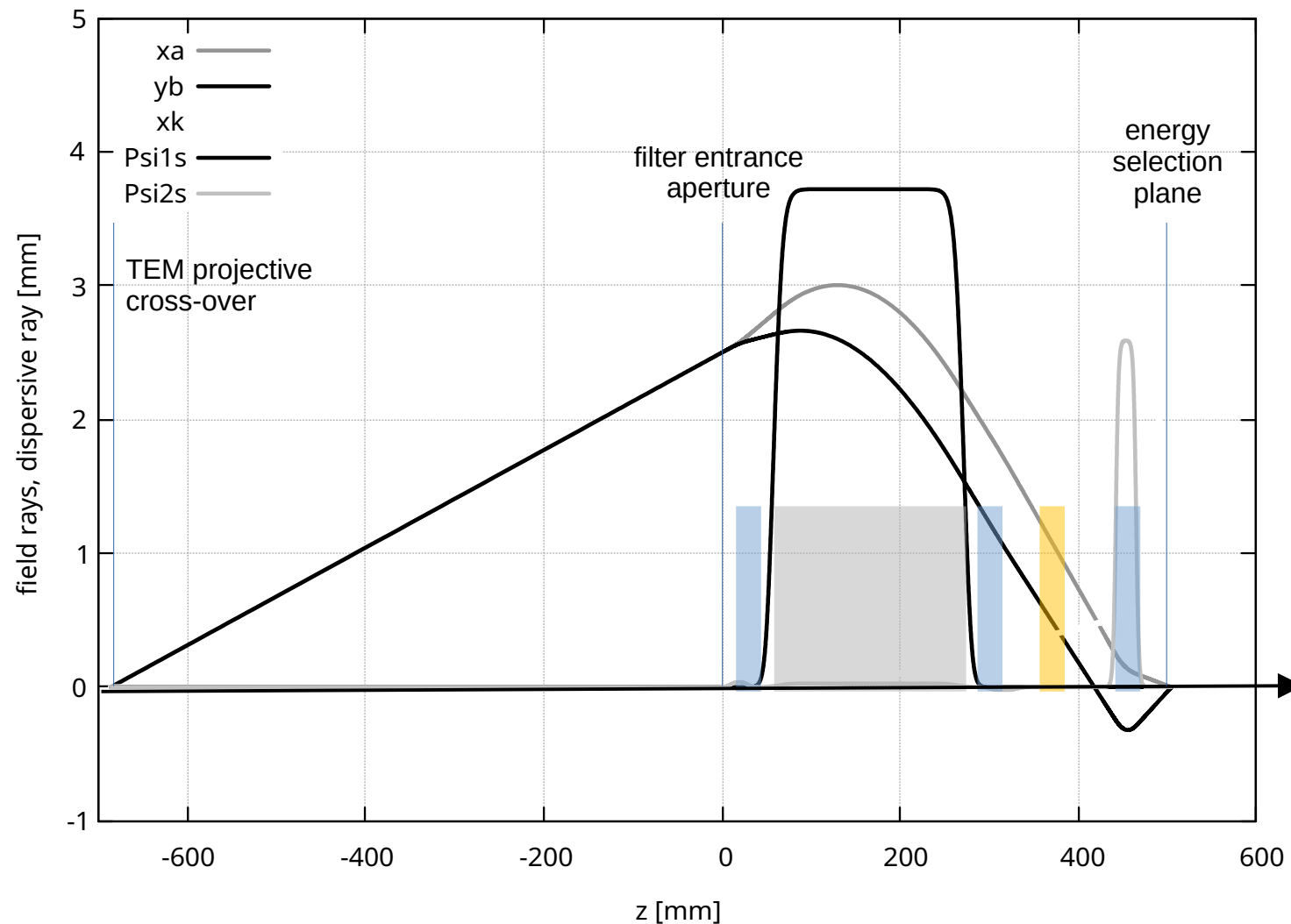
Course of optic axis and homocentric bundle.



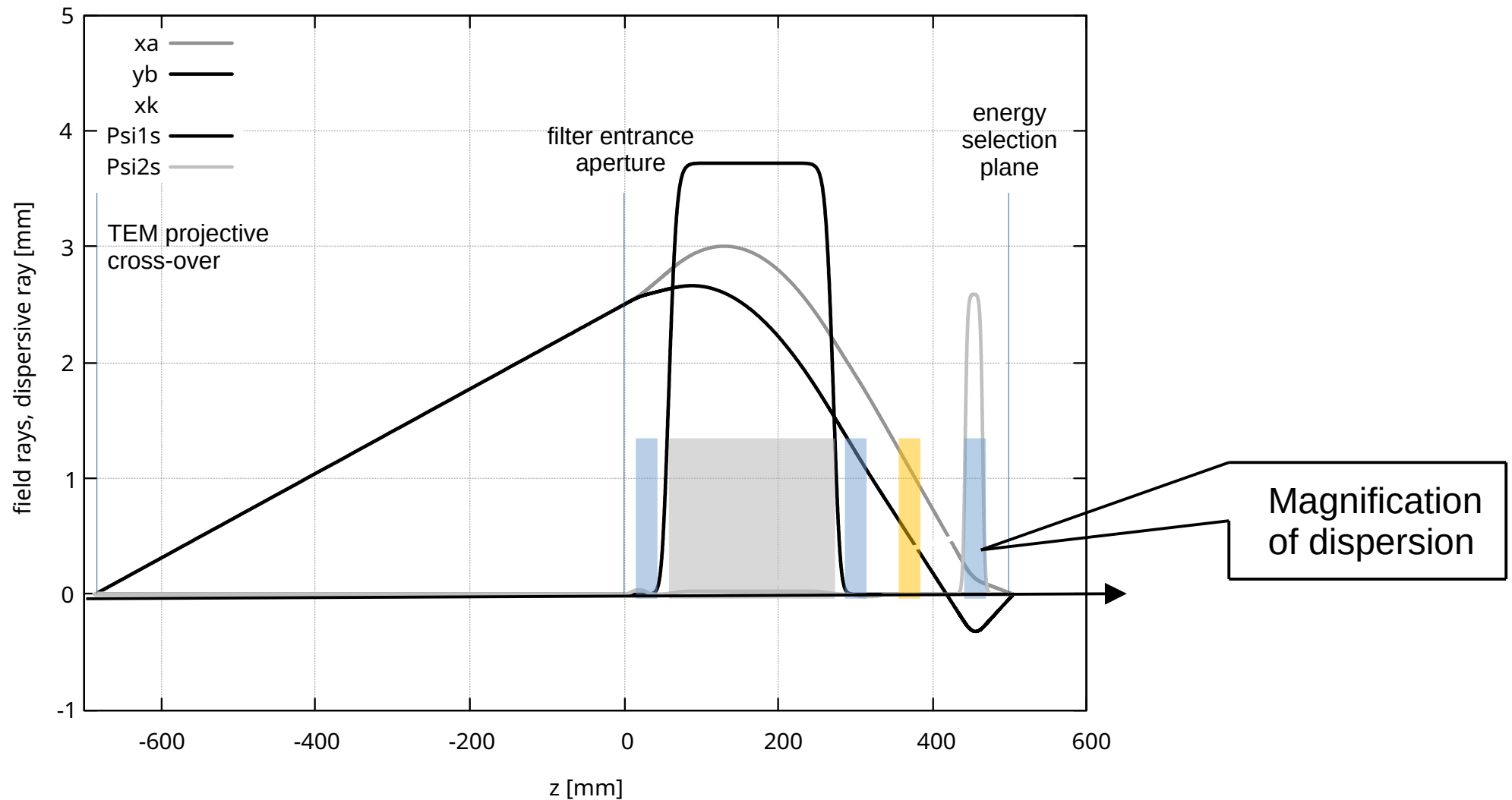
Straightened optic axis and axial rays.



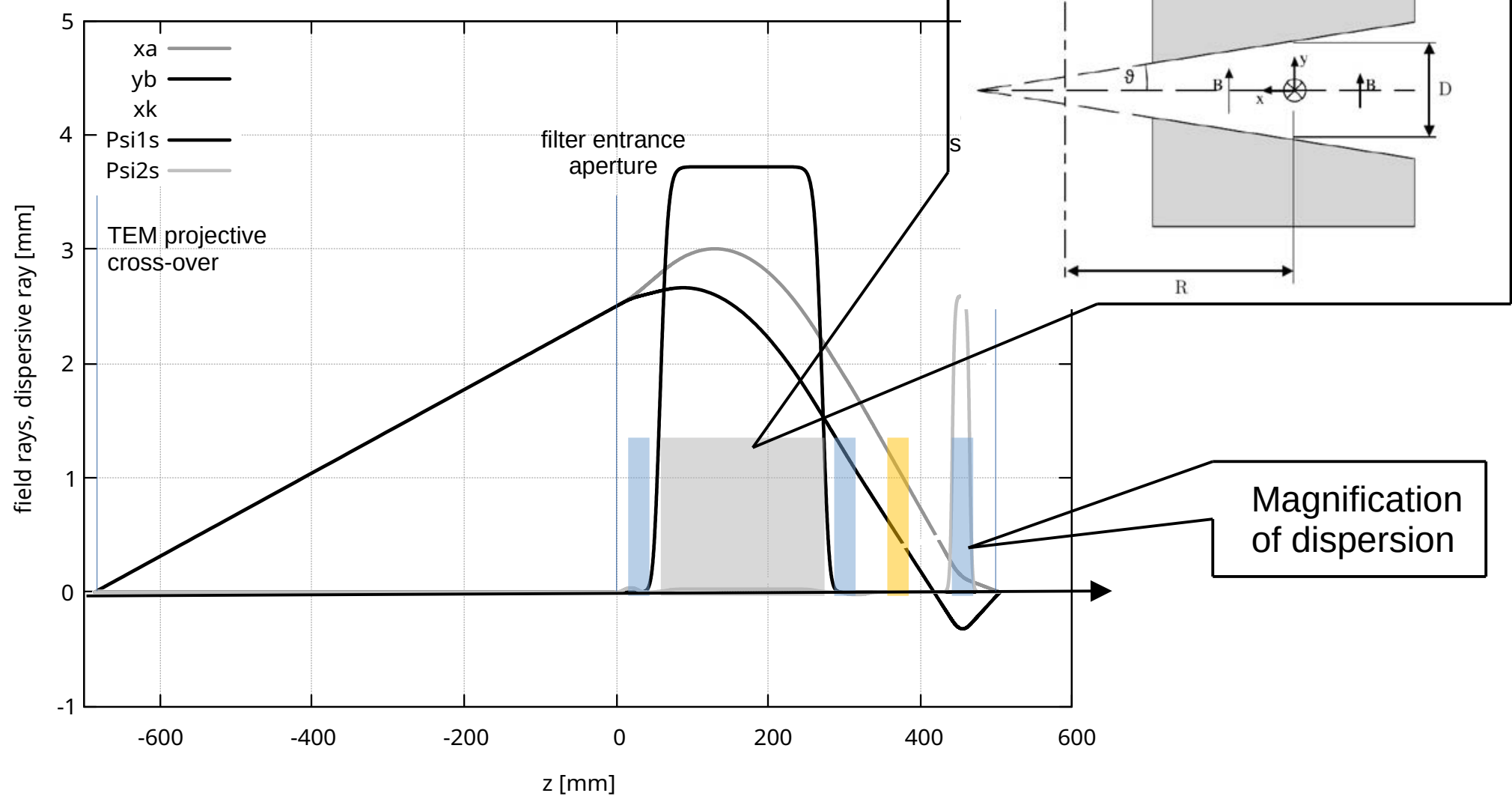
Pre-slit raypath of real spectrometer:



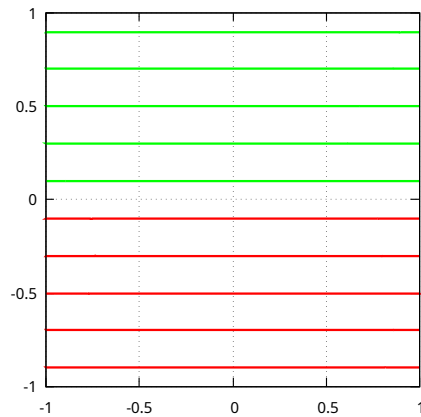
Pre-slit raypath of real spectrometer:



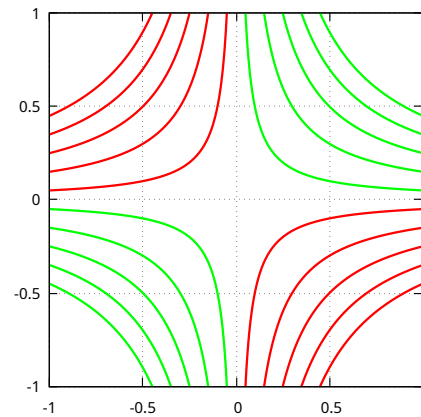
Pre-slit raypath of real spectrometer:



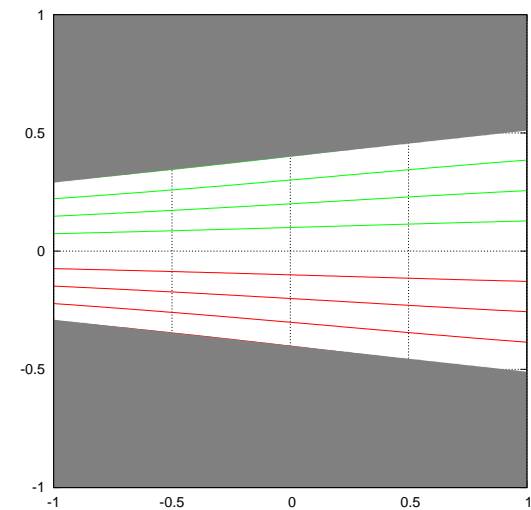
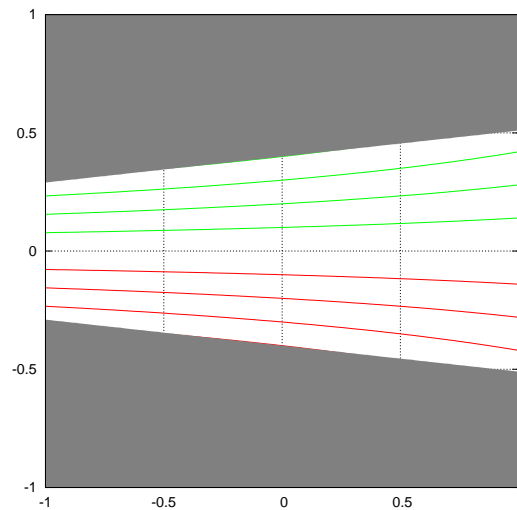
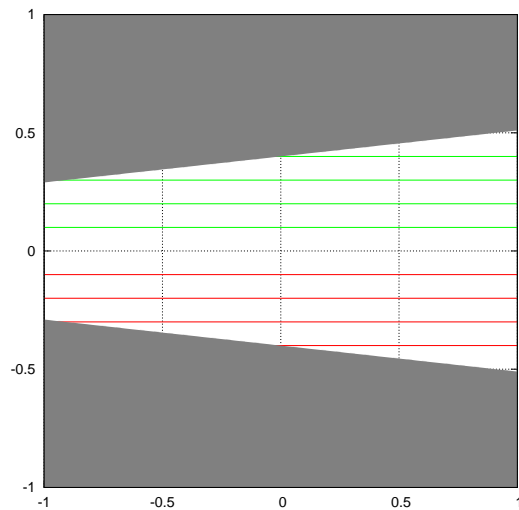
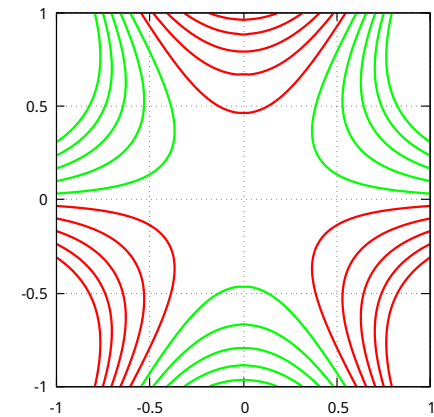
Dipole

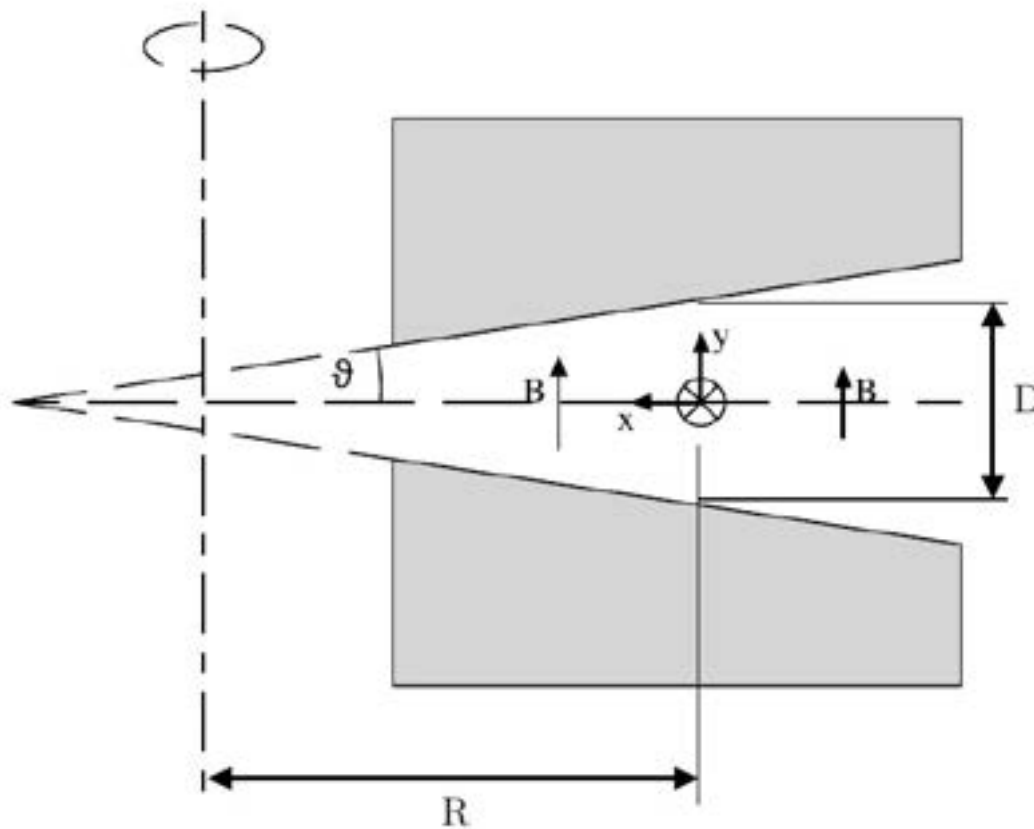


Quadrupole



Hexapole





Magn. Field (Dipole Strength):

$$B = -\Psi_{1s} = \frac{1}{\eta R}$$

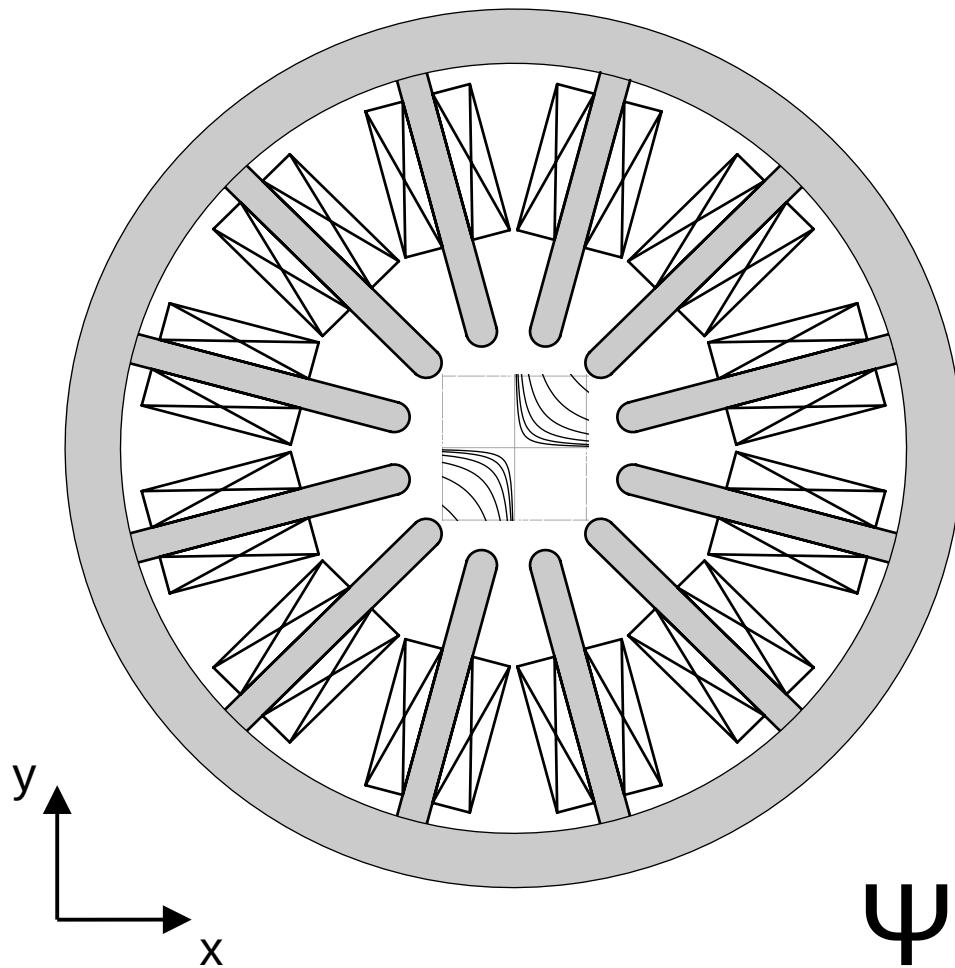
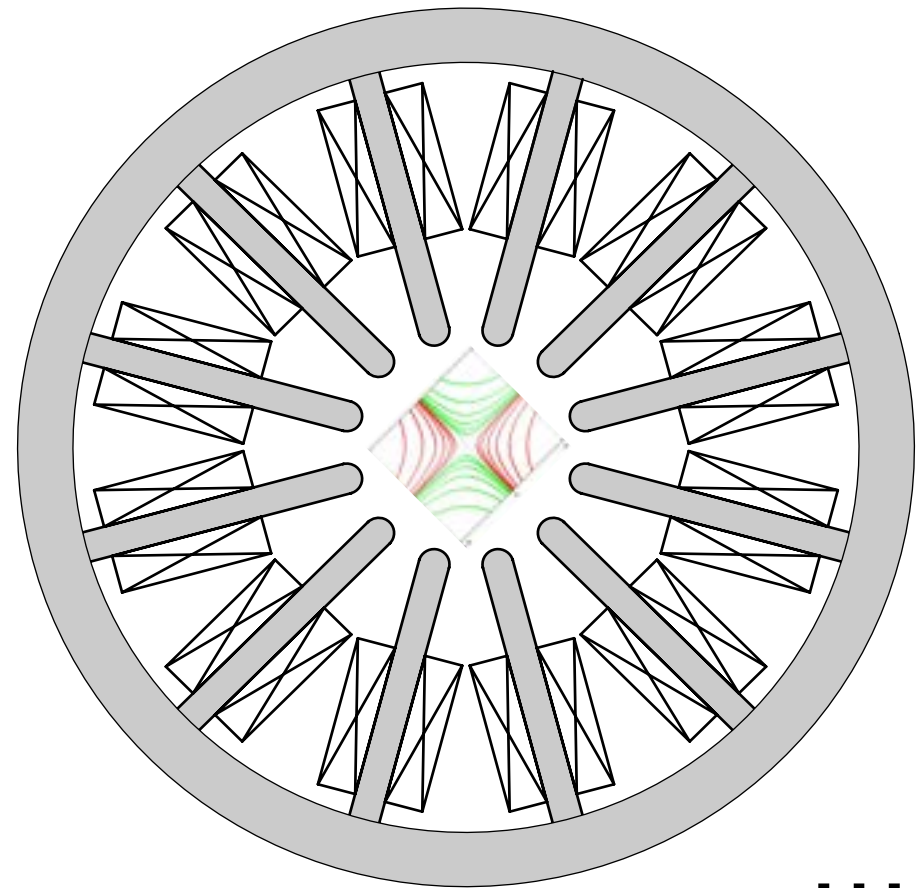
Quadrupole Strength:

$$\Psi_{2s} = \frac{1}{R} \xi \Psi_{1s}, \quad \xi = \frac{R}{D} \tan(\vartheta)$$

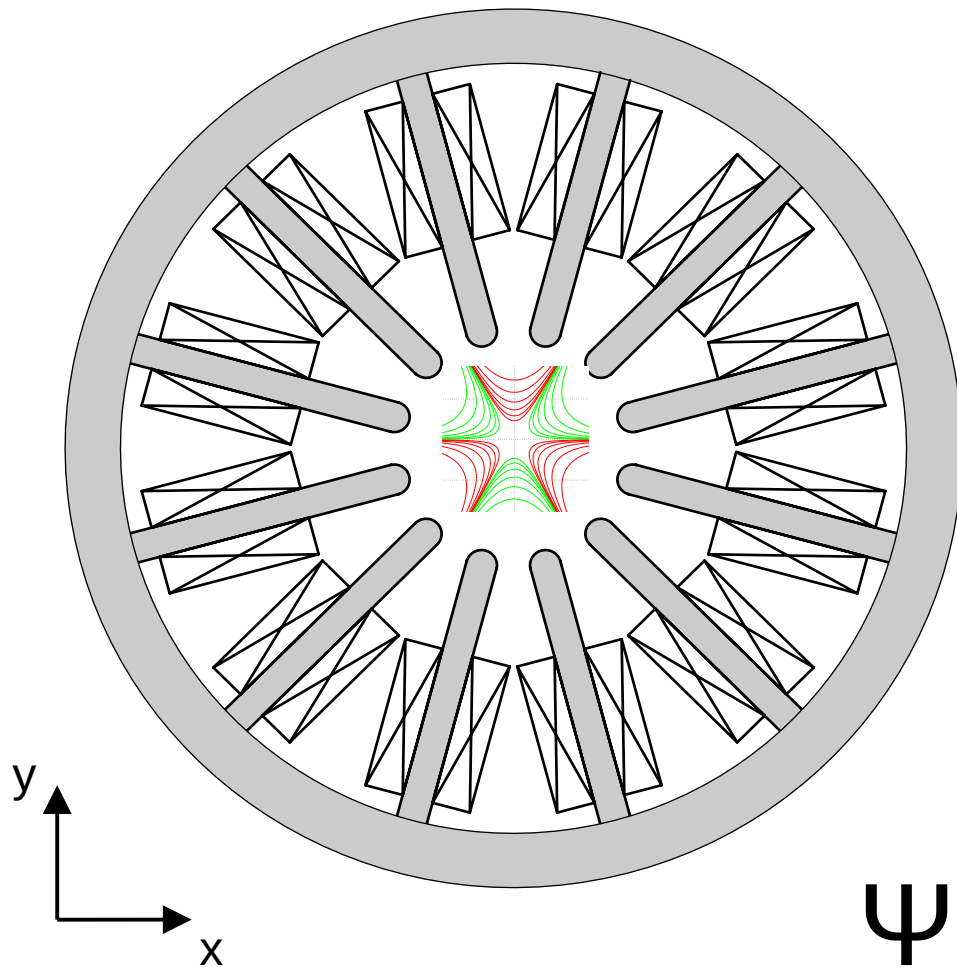
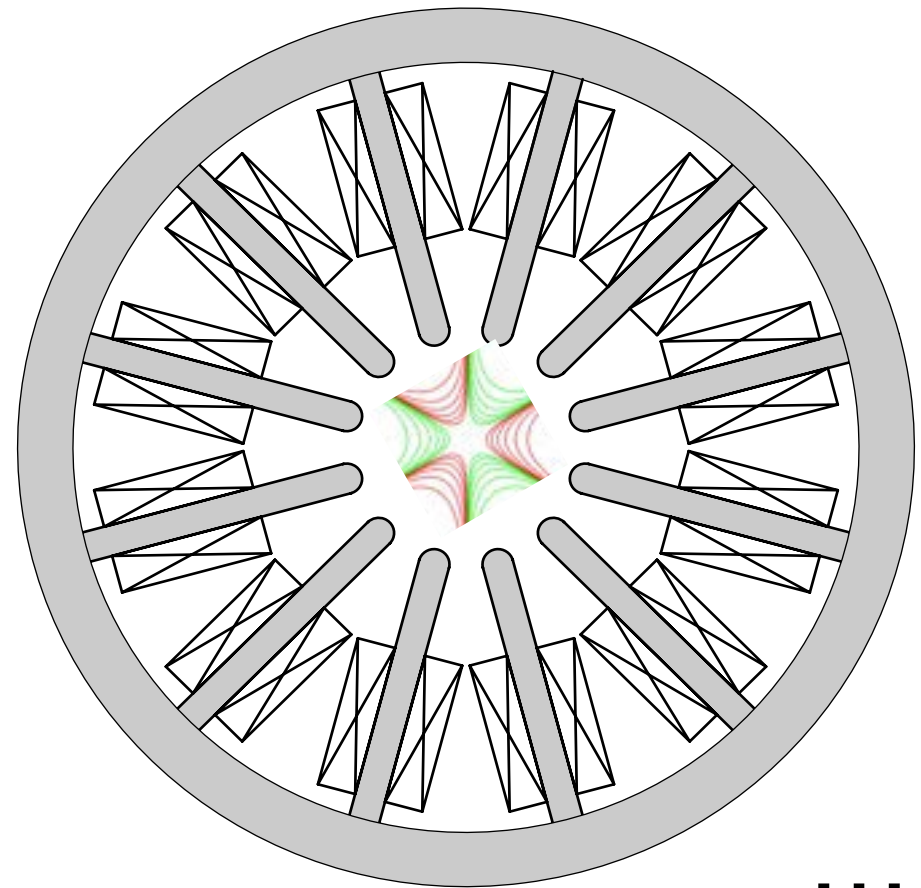
Hexapole Strength:

$$\Psi_{3s} = \frac{1}{12R^2} (16\xi^2 - \xi) \Psi_{1s}$$

Dodecapole for correction of spectrum aberrations (NI):

 Ψ_{2s}  Ψ_{2c}

Dodecapole for correction of spectrum aberrations (NI):

 Ψ_{3s}  Ψ_{3c}

Aberrations a energy-selection plane:

α, β : coordinates in filter entrance aperture $\kappa = \frac{\Delta E}{E_0}$: chromatic parameter

Rank 1:

$$x^{(1)}(\alpha, \beta, \kappa) = \alpha x_\alpha + \beta x_\beta + \kappa x_\kappa$$

$$y^{(1)}(\alpha, \beta, \kappa) = \beta y_\beta$$

mirror symmetry: $y \leftrightarrow -y$

Rank 2:

$$x^{(2)}(\alpha, \beta, \kappa) = \alpha^2 x_{\alpha\alpha} + \beta^2 x_{\beta\beta} + \alpha\beta x_{\alpha\beta} + \alpha\kappa x_{\alpha\kappa}$$

Rank 3:

$$x^{(3)}(\alpha, \beta, \kappa) = \alpha^3 x_{\alpha\alpha\alpha} + \alpha\beta^2 x_{\alpha\beta\beta} + \alpha^2\beta x_{\alpha\alpha\beta} + \beta^3 x_{\beta\beta\beta}$$

Aberrations a energy-selection plane:

α, β : coordinates in filter entrance aperture $\kappa = \frac{\Delta E}{E_0}$: chromatic parameter

Rank 1: (3 x Ψ_{2s} , 1 x Ψ_{2c})

$$x^{(1)}(\alpha, \beta, \kappa) = \alpha x_\alpha + \beta x_\beta + \kappa x_\kappa$$

$$y^{(1)}(\alpha, \beta, \kappa) = \beta y_\beta$$

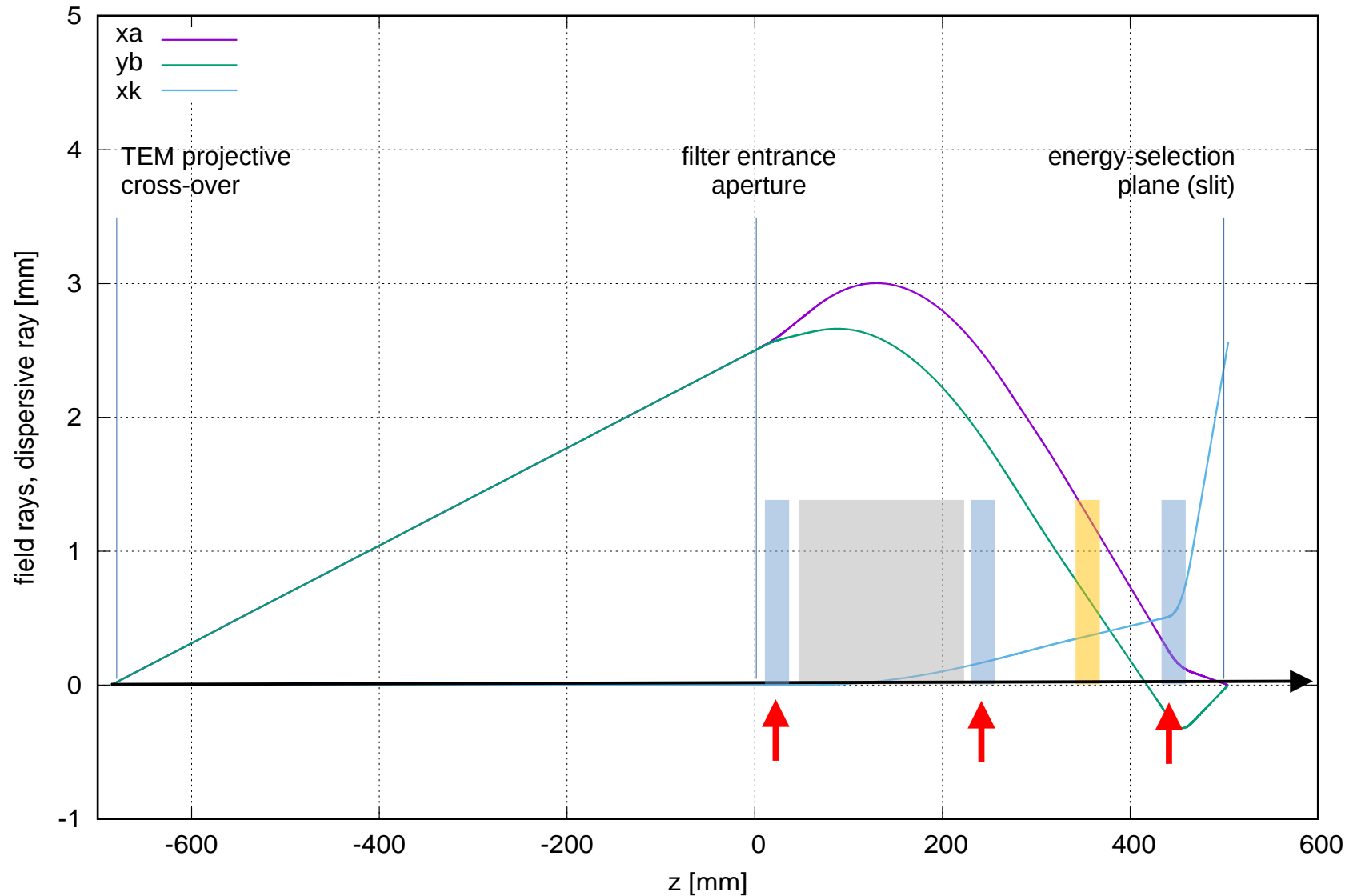
mirror symmetry: $y \leftrightarrow -y$

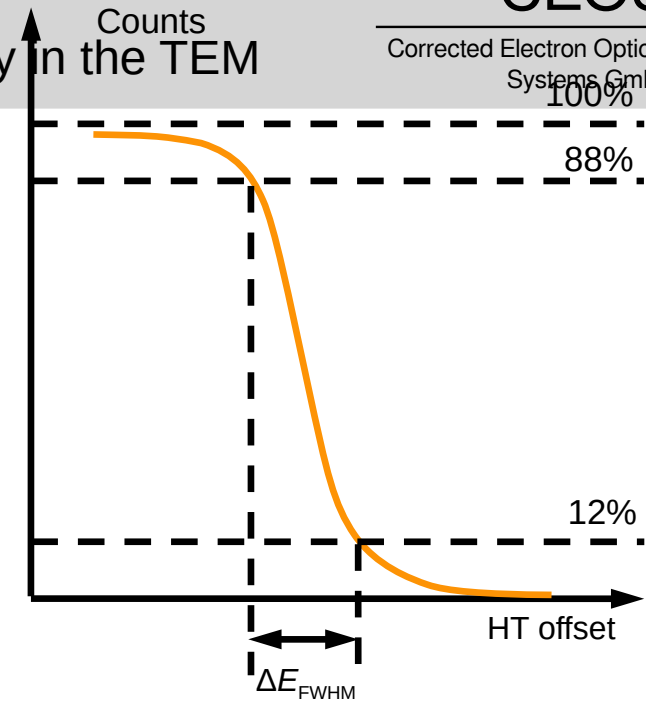
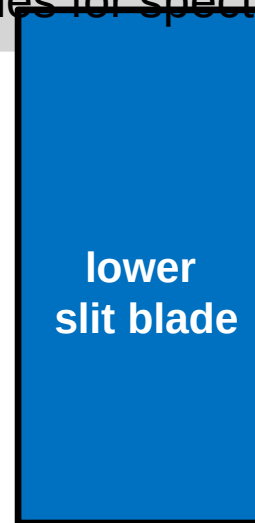
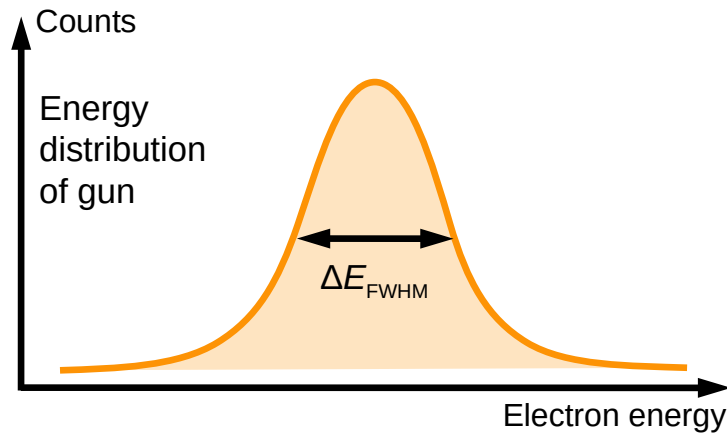
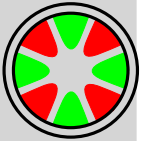
Rank 2: (2 x Ψ_{3s} , 1 x Ψ_{3c} , ??)

$$x^{(2)}(\alpha, \beta, \kappa) = \alpha^2 x_{\alpha\alpha} + \beta^2 x_{\beta\beta} + \alpha\beta x_{\alpha\beta} + \alpha\kappa x_{\alpha\kappa}$$

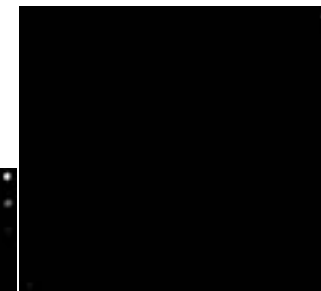
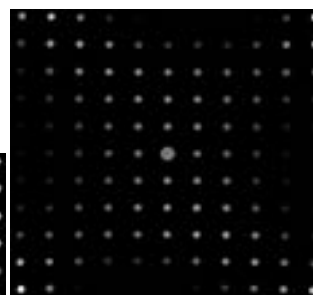
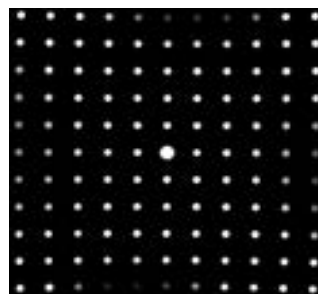
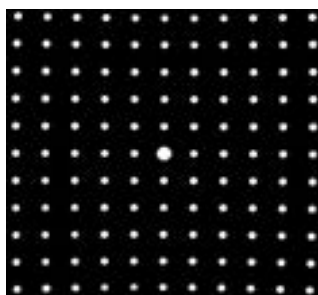
Rank 3: (2 x Ψ_{4s} , 2 x Ψ_{4c})

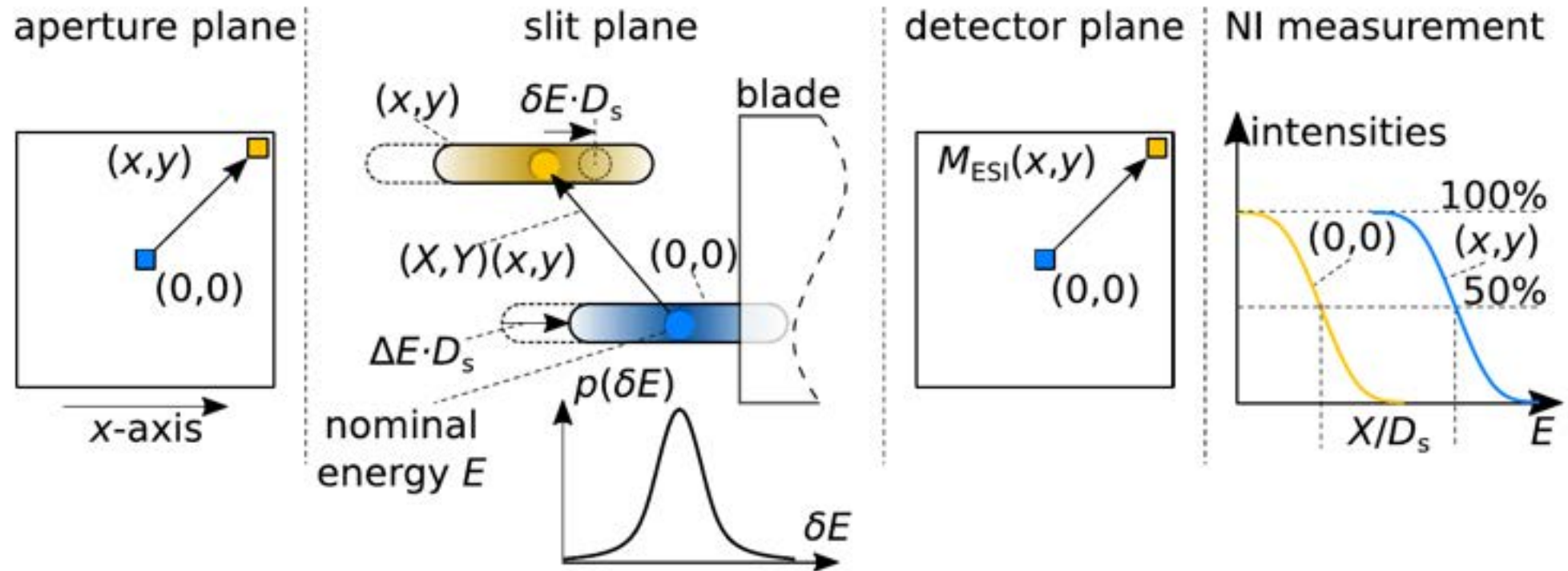
$$x^{(3)}(\alpha, \beta, \kappa) = \alpha^3 x_{\alpha\alpha\alpha} + \alpha\beta^2 x_{\alpha\beta\beta} + \alpha^2\beta x_{\alpha\alpha\beta} + \beta^3 x_{\beta\beta\beta}$$



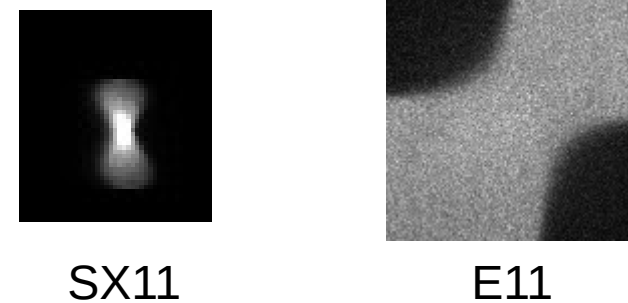
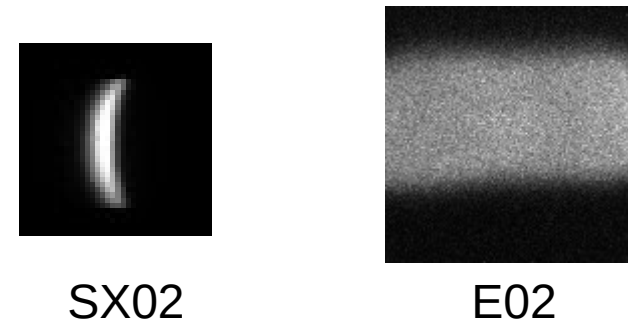
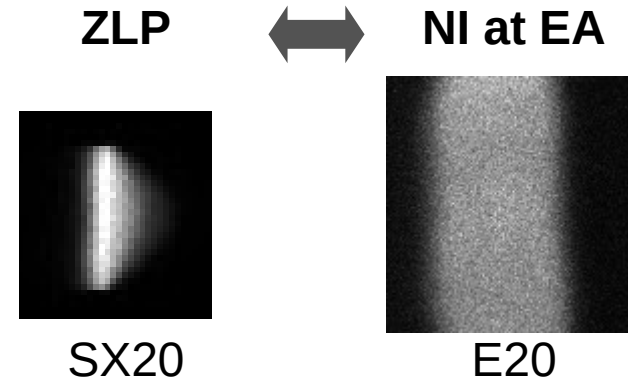
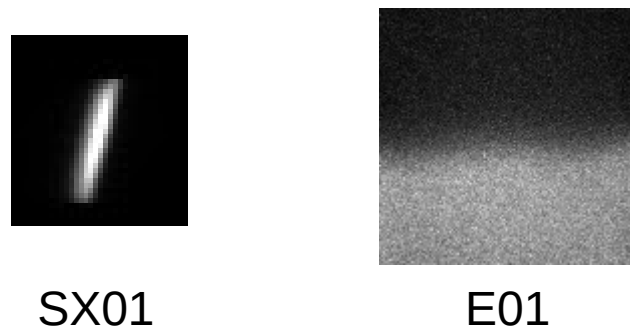
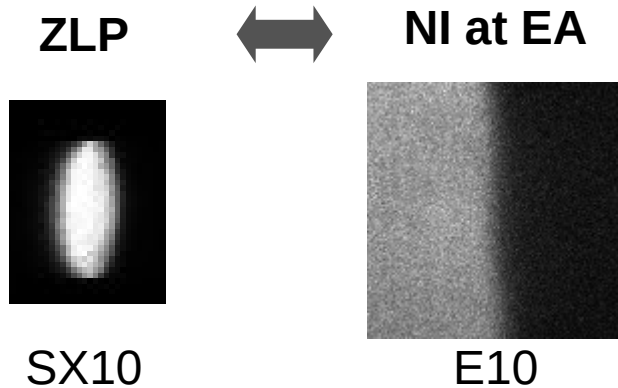


ΔHT : 0 eV 0.36 eV 0.72 eV 1.08 eV 1.44 eV



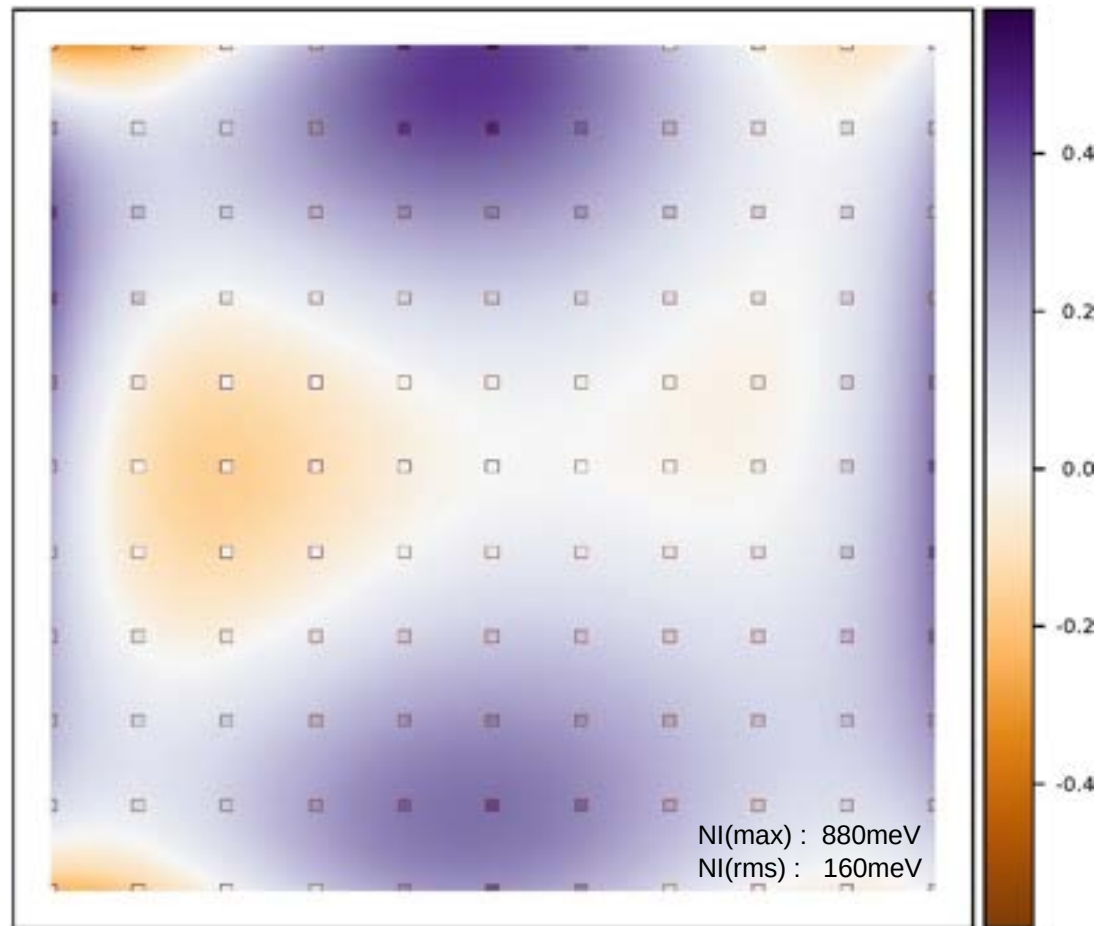


$$E(x, y, \Delta E) = \Delta E + \sum_{r \geq 0} \sum_{\substack{m=0 \\ n=r-m}}^r E_{nm} x^n y^m,$$

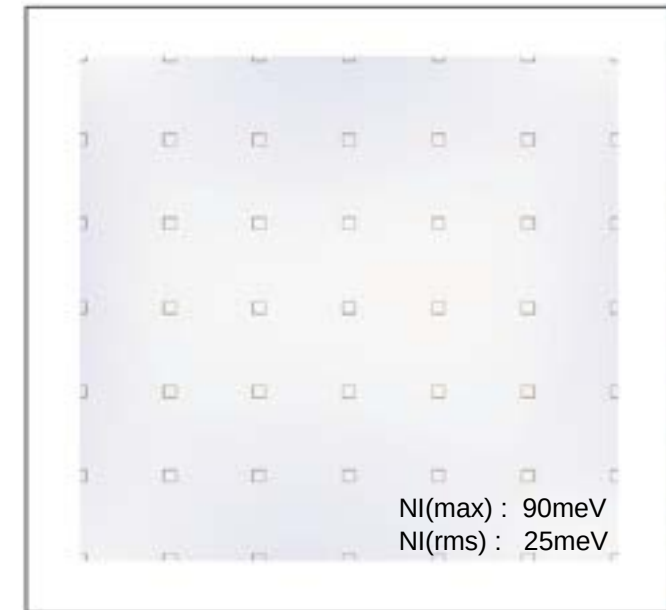


***Measurement of pre-slit
aberrations in imaging (ESI)
mode is more robust and
quantitative than in EELS mode***

CEFID Isochromaticity at 200kV

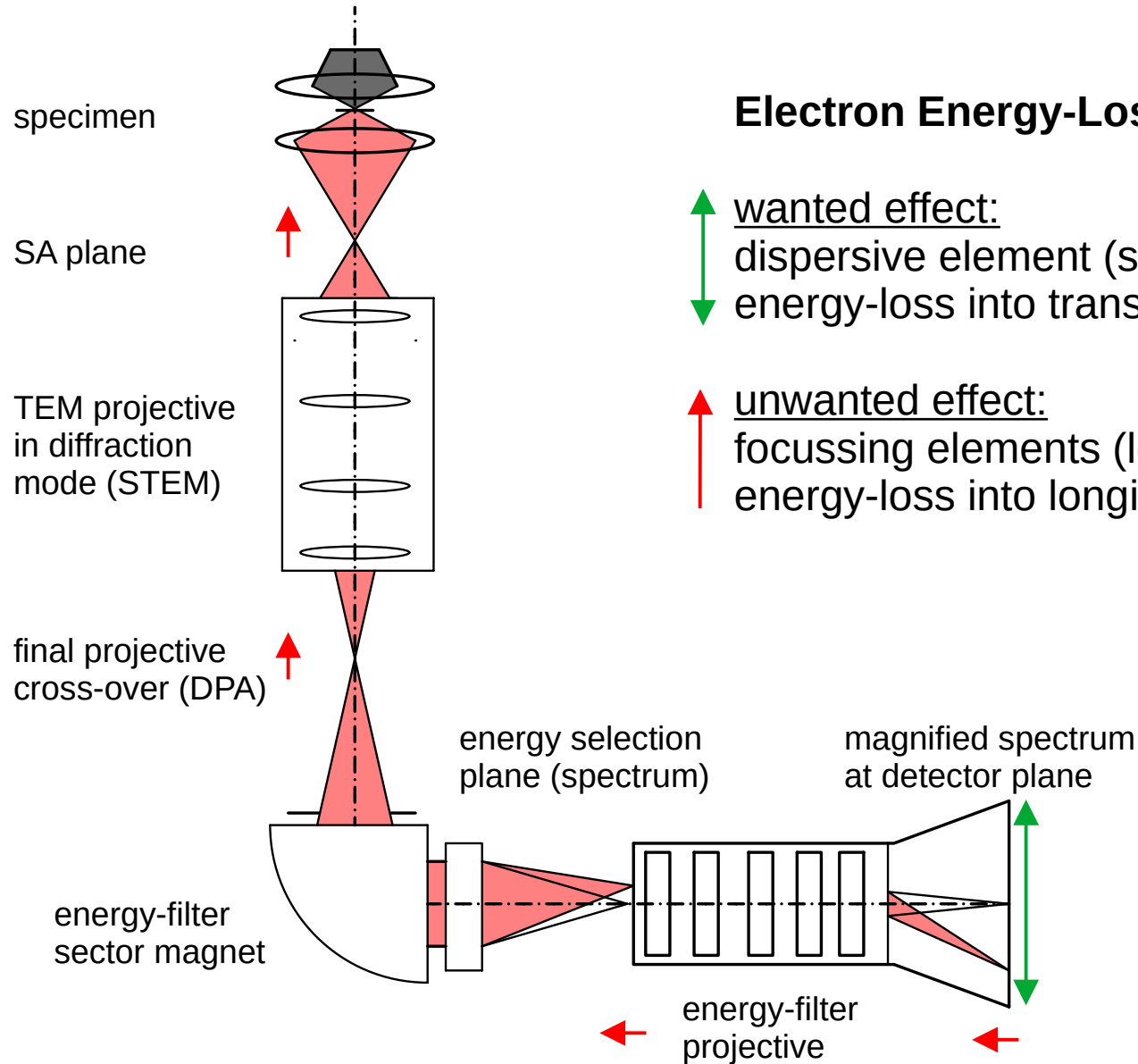


ESI 12mm 11x11



ESI 8mm 7x7

Electron Energy-Loss Spectroscopy



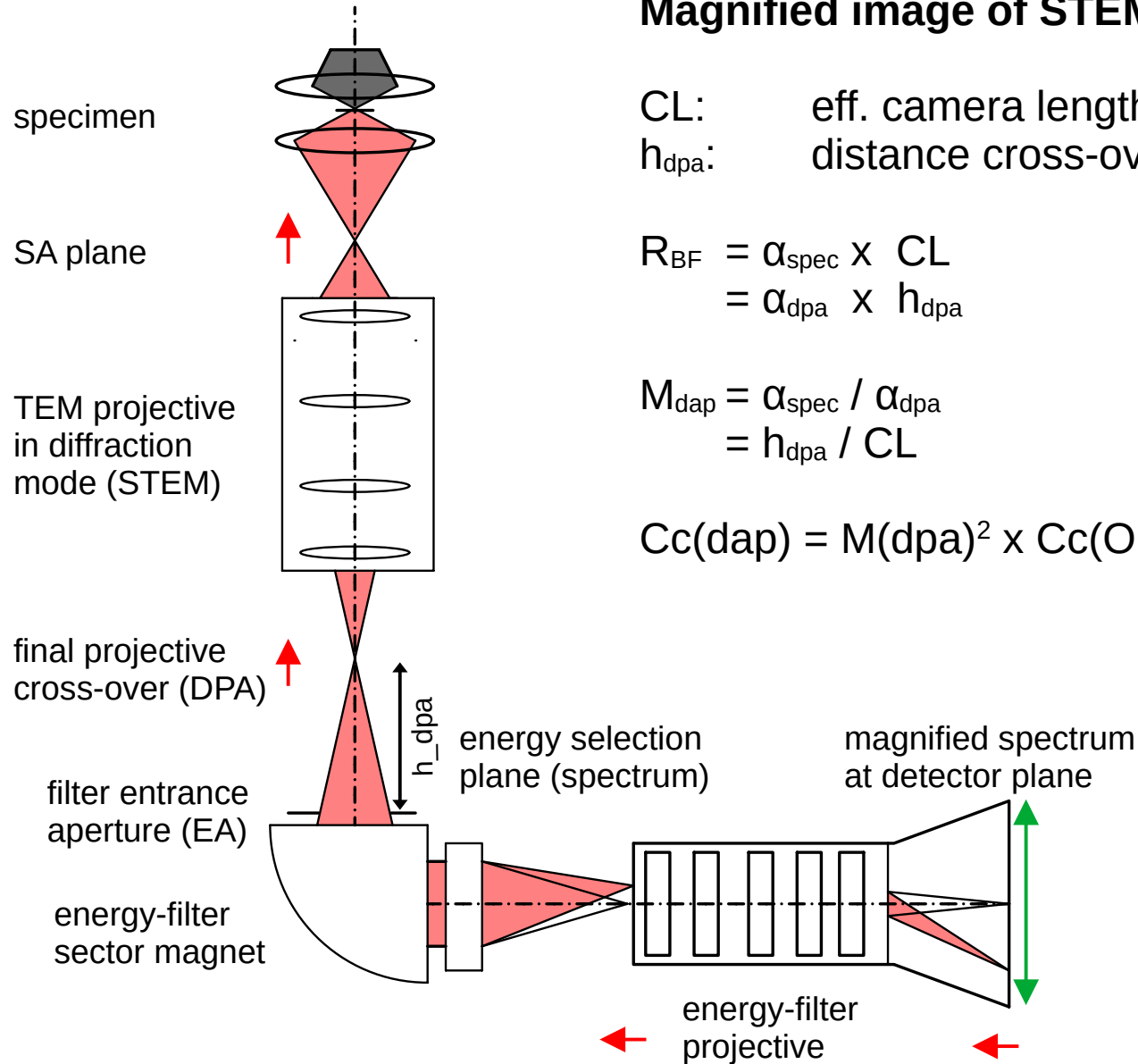
↑ wanted effect:

↓ dispersive element (sector magnet) translates
energy-loss into transversal displacement

↑ unwanted effect:

↑ focussing elements (lenses, quadrupoles) translate
energy-loss into longitudinal shift of focus plane

Magnified image of STEM probe at DPA plane:



Chromatic defocus at DPA plane:

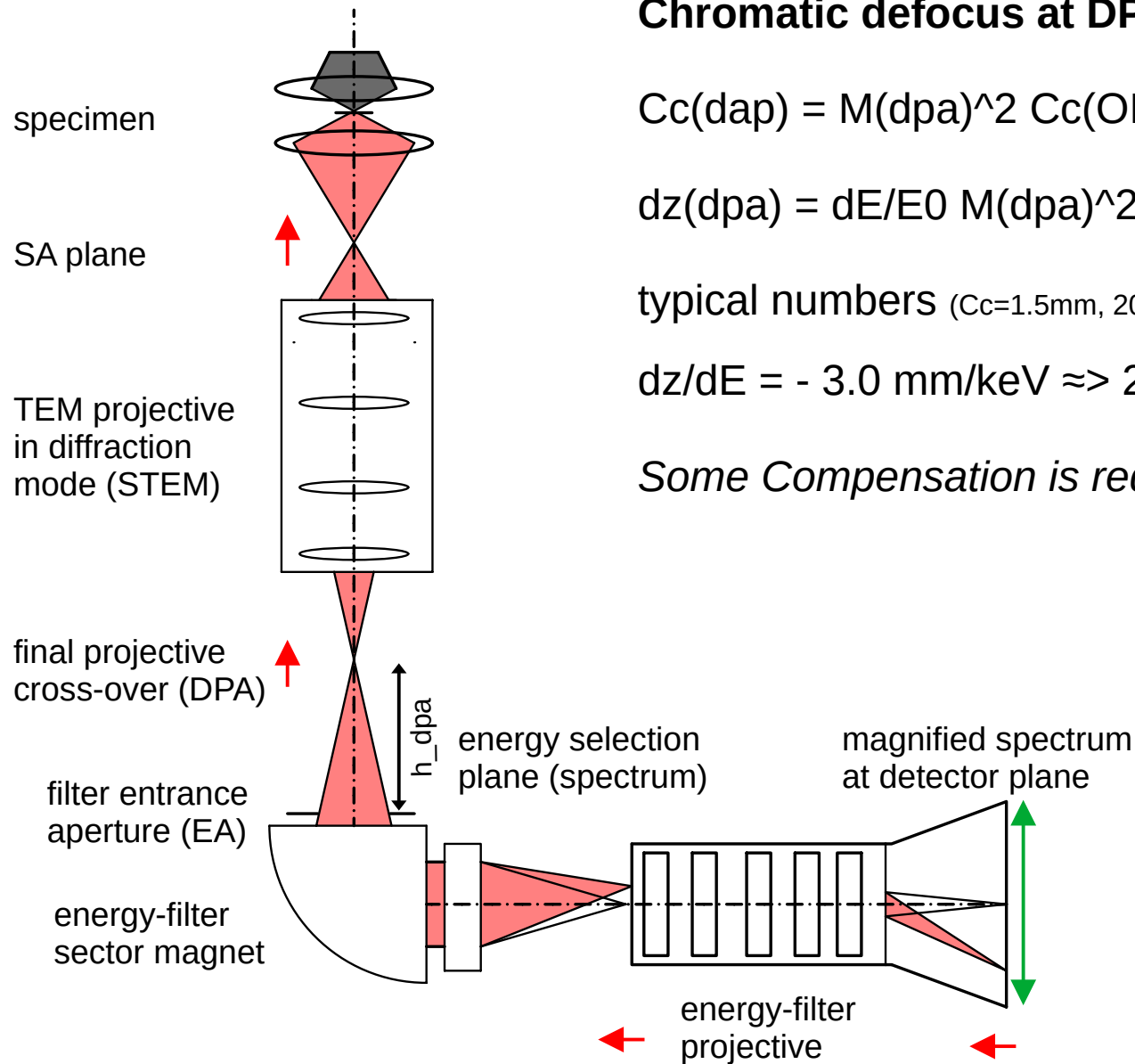
$$Cc(dpa) = M(dpa)^2 Cc(OL)$$

$$dz(dpa) = dE/E_0 M(dpa)^2 Cc(OL)$$

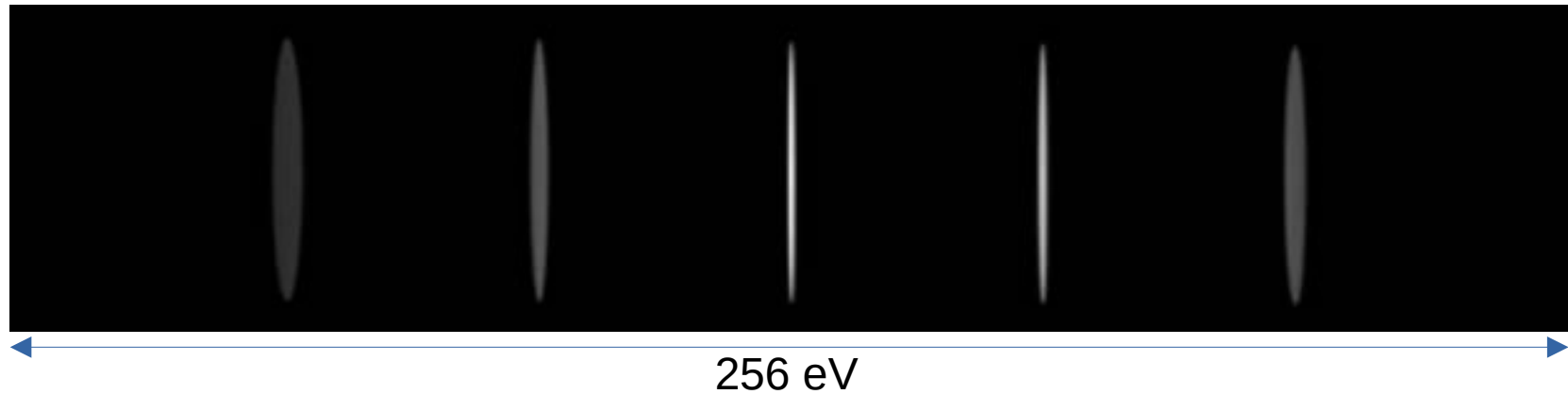
typical numbers ($Cc=1.5\text{mm}$, 200kV , $CL=30\text{mm}$, $h_{DPA}=600\text{mm}$):

$$dz/dE = -3.0 \text{ mm/keV} \approx 2.6 \text{ eV/keV (30mrad)}$$

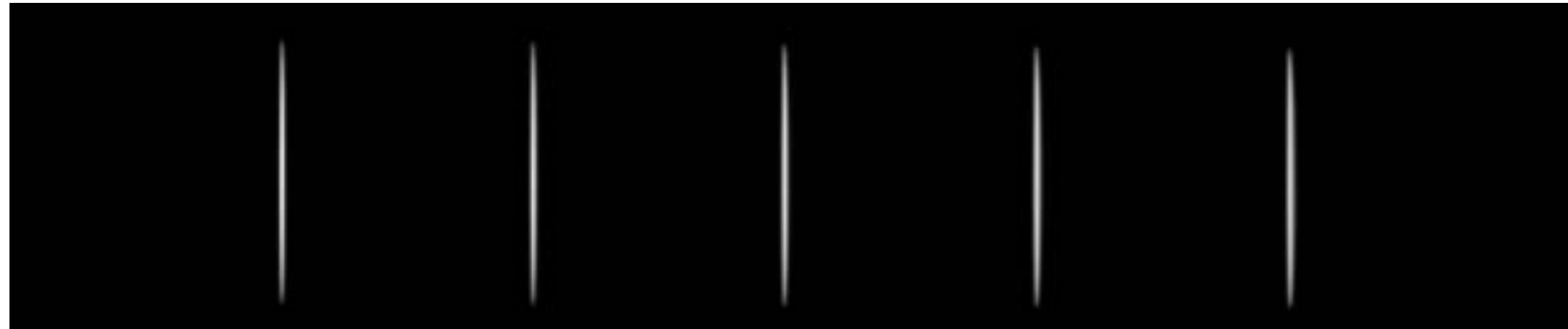
Some Compensation is required!



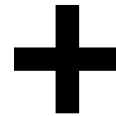
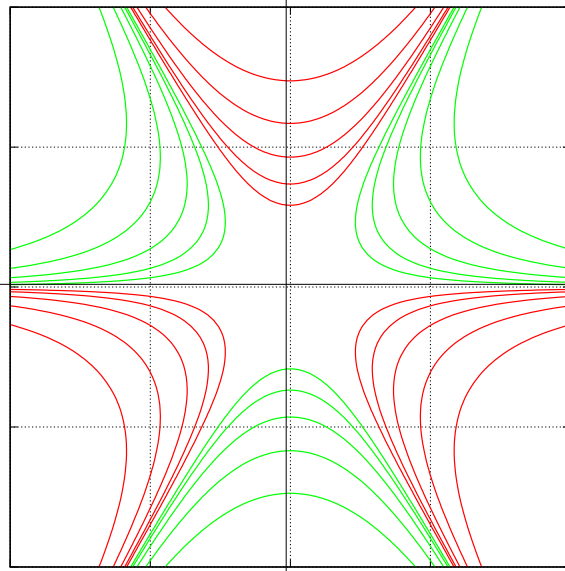
Focussed but spectrum inclination not corrected:



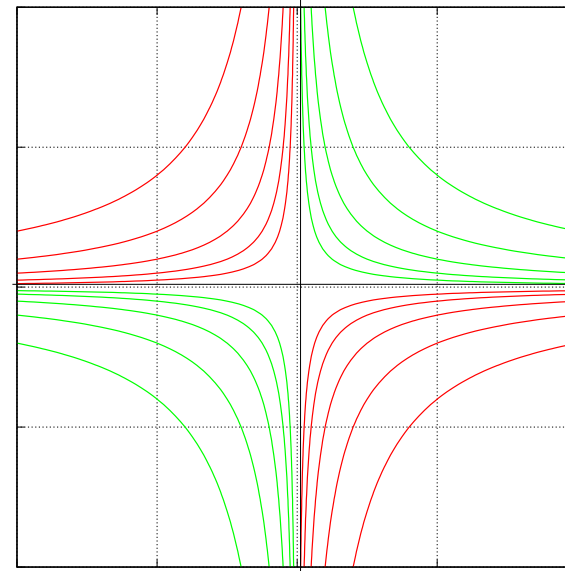
Focussed and spectrum inclination corrected:



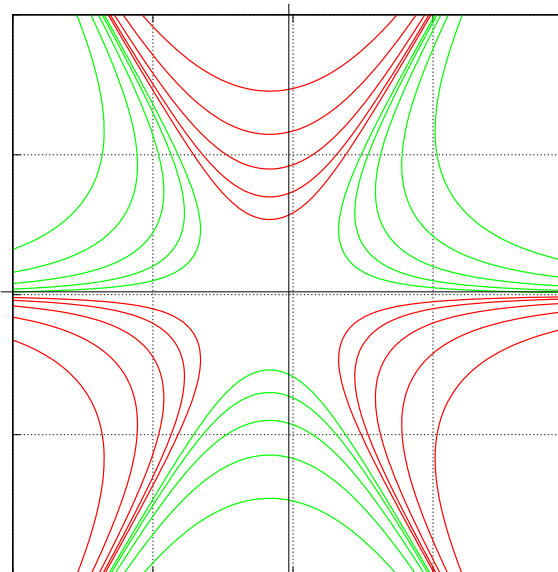
hexpole
potential

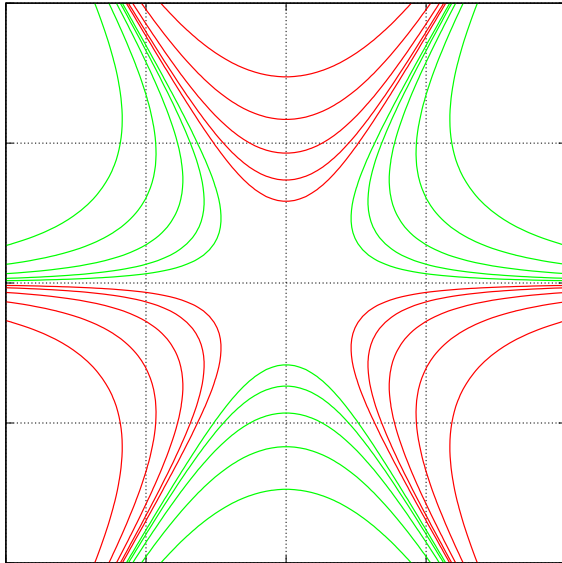


quadrupole
potential



shifted
potential
or
superimposed
quadrupole





quadrupole potential:

$$\psi_2 = \underline{2\Psi_{2s}xy}$$

hexapole potential:

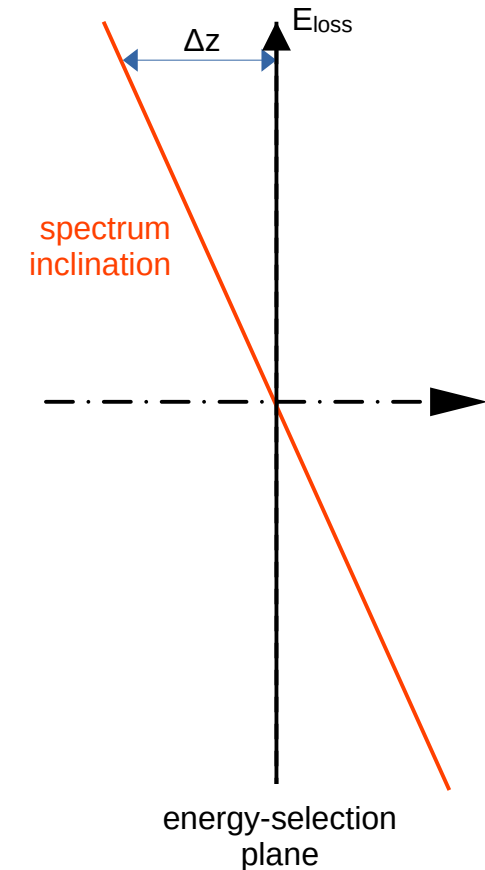
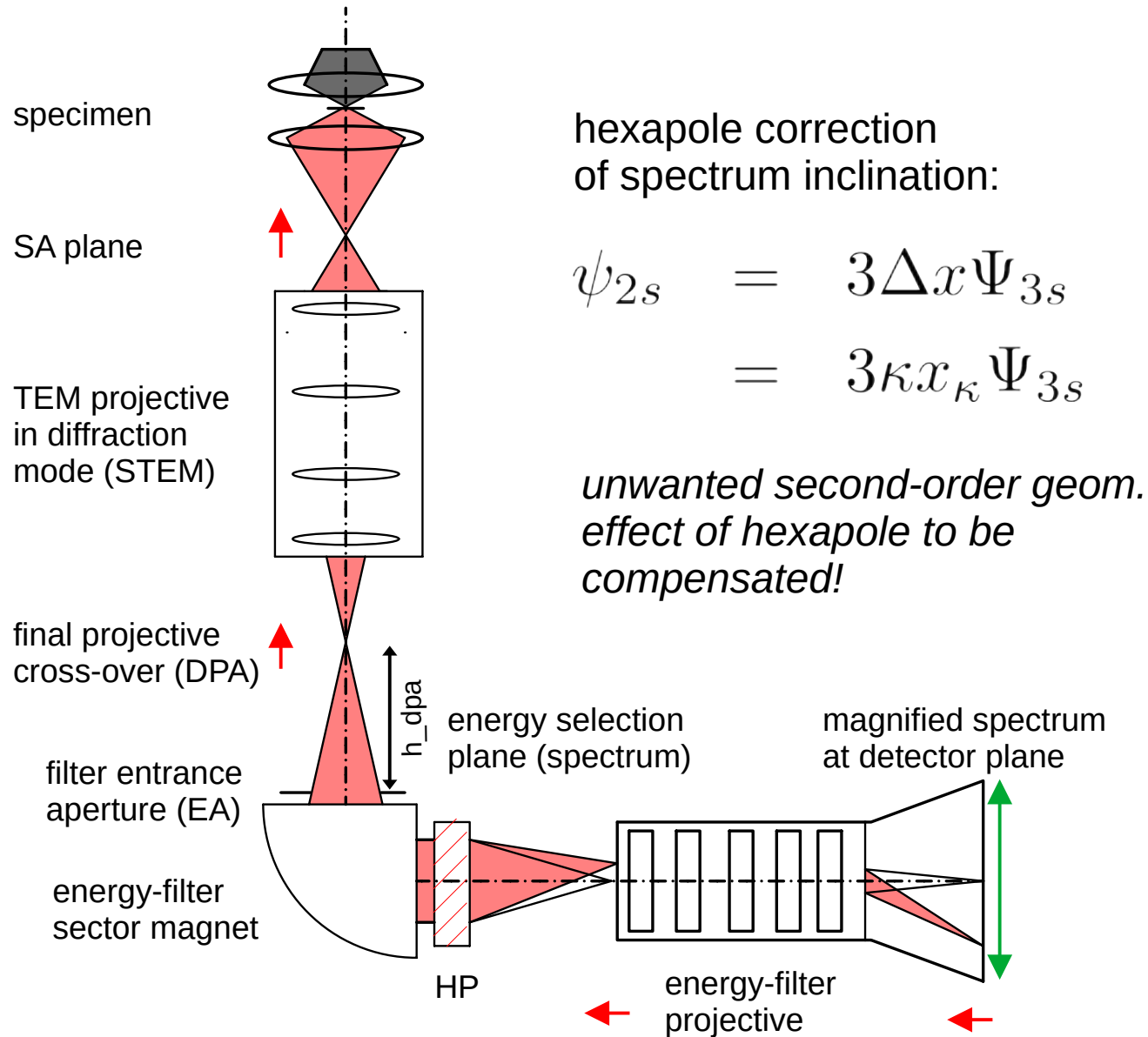
$$\psi_3 = \Psi_{3s} (y^3 + 3x^2y)$$

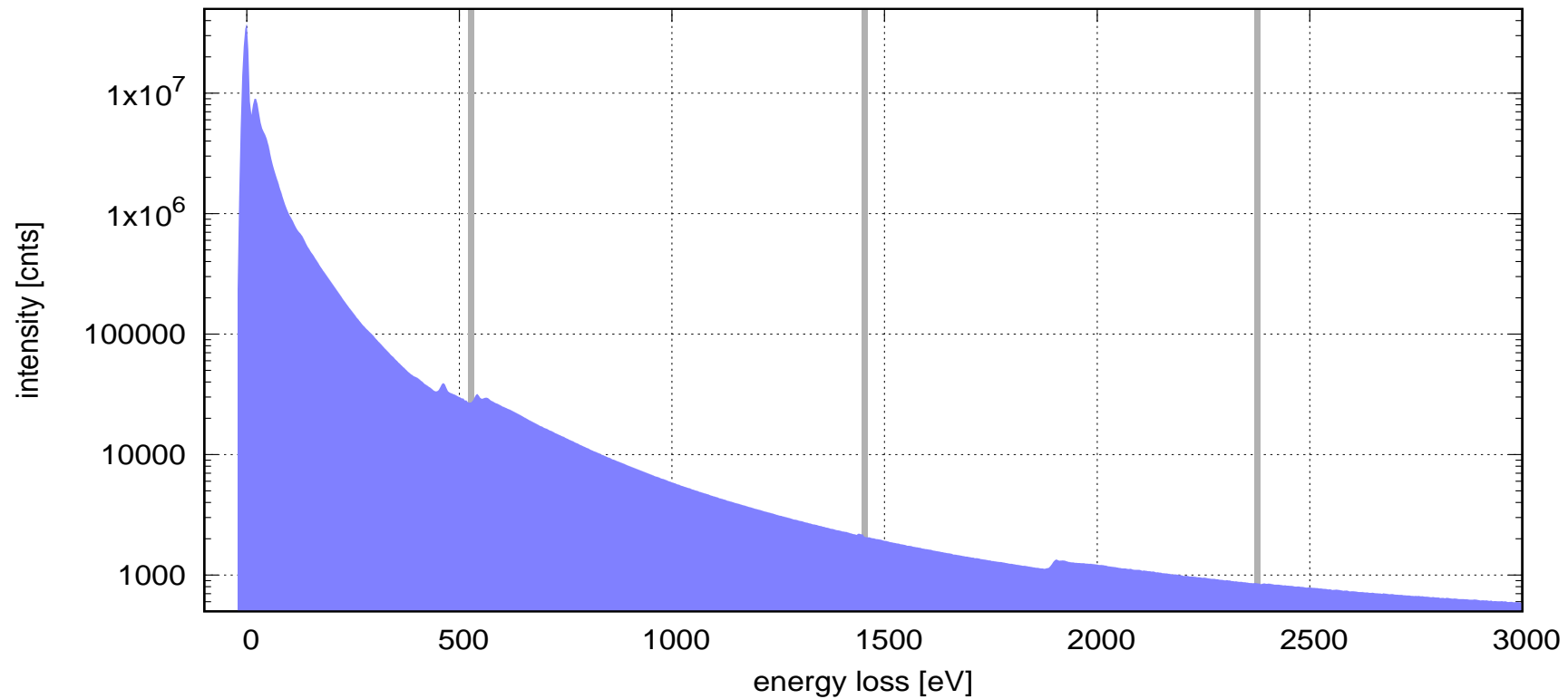
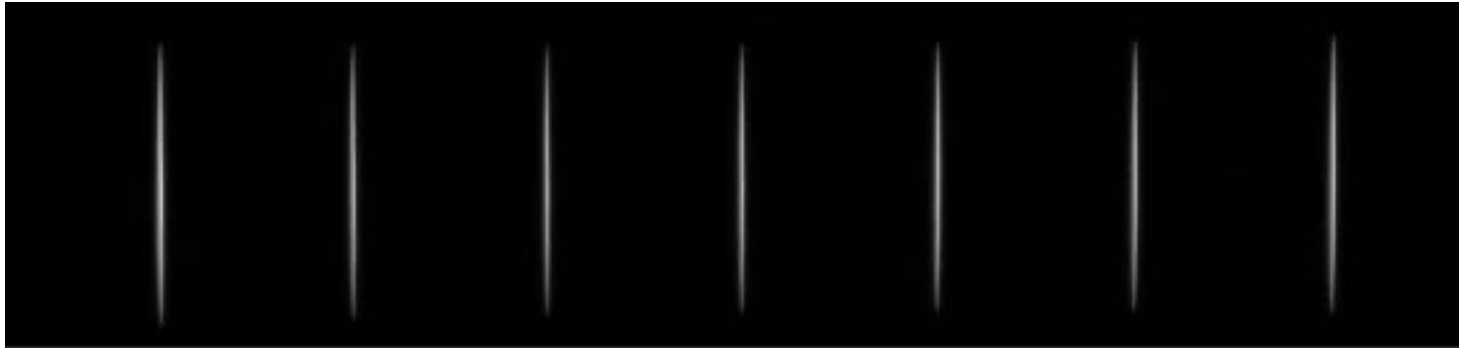
shift of optic axis:

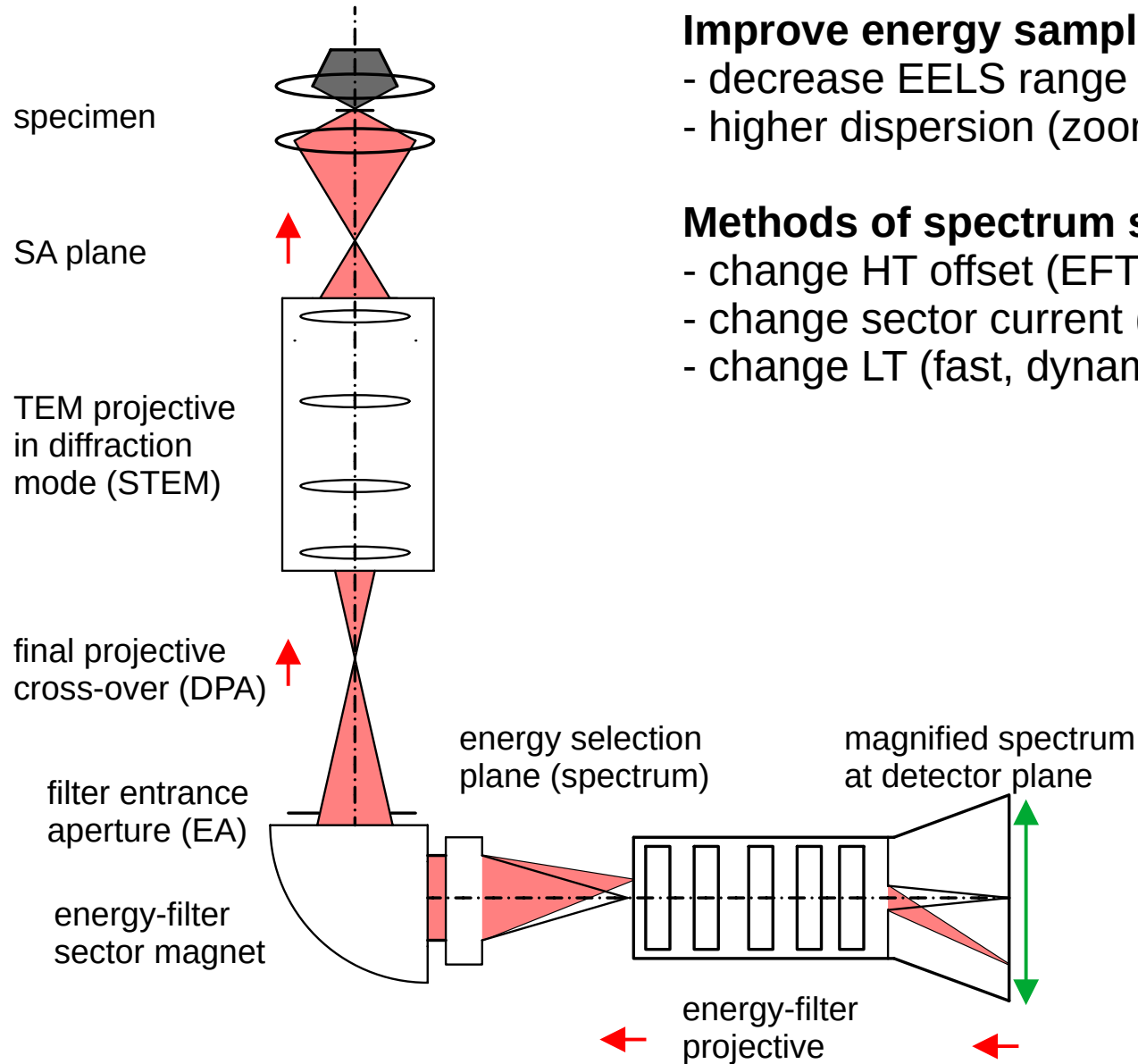
$$\begin{aligned}\psi &= \Psi_{3s} \left(y^3 + 3(x + \Delta x)^2 y \right) \\ &\approx \Psi_{3s} (y^3 + 3x^2y) + \underline{6\Delta x\Psi_{3s}xy}\end{aligned}$$

shift-induced quadrupole strength:

$$\psi_{2s} = 3\Delta x\Psi_{3s}$$





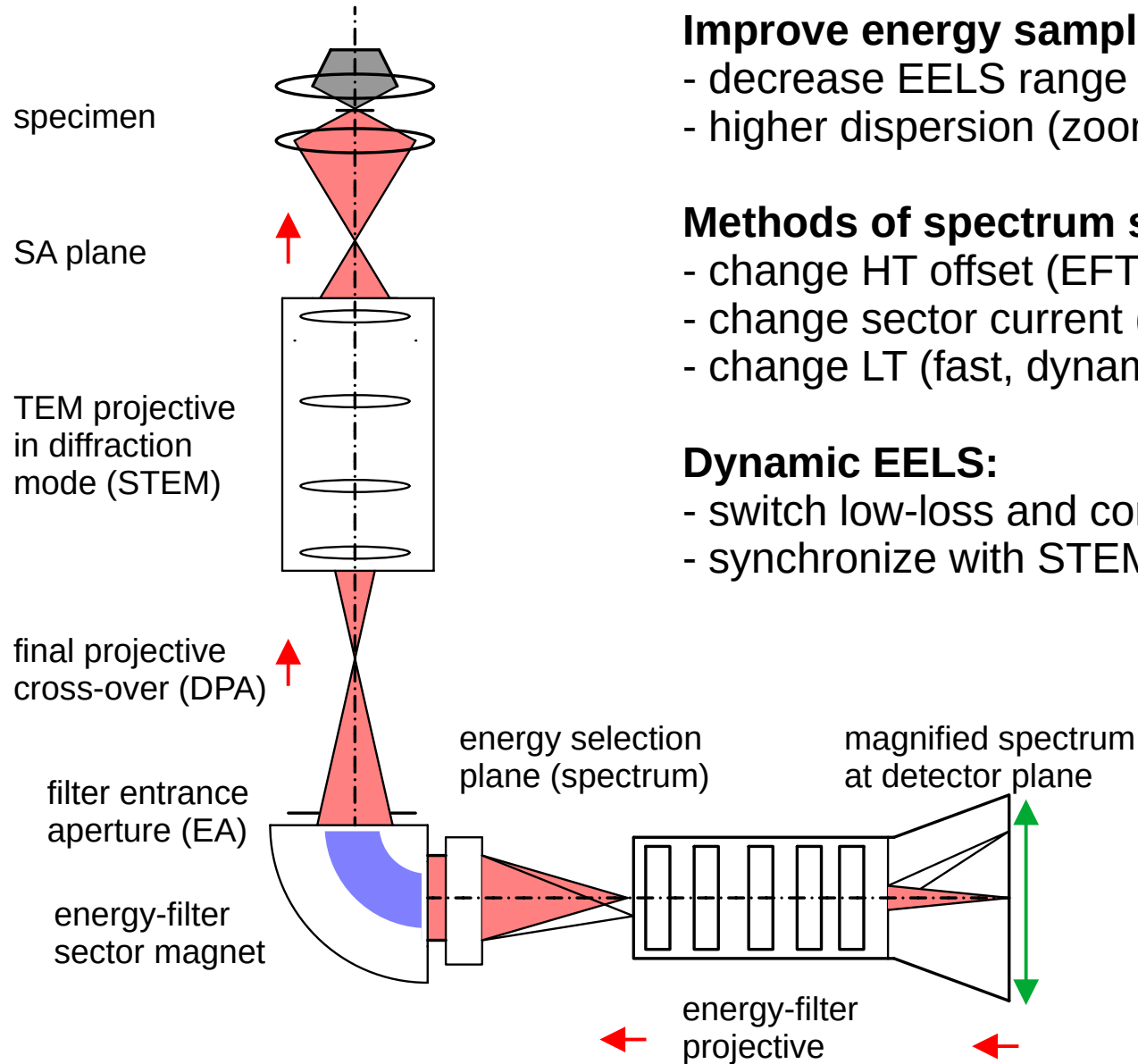


Improve energy sampling:

- decrease EELS range
- higher dispersion (zoom in)

Methods of spectrum shift:

- change HT offset (EFTEM)
- change sector current (high-loss, slow)
- change LT (fast, dynamic EELS)



Improve energy sampling:

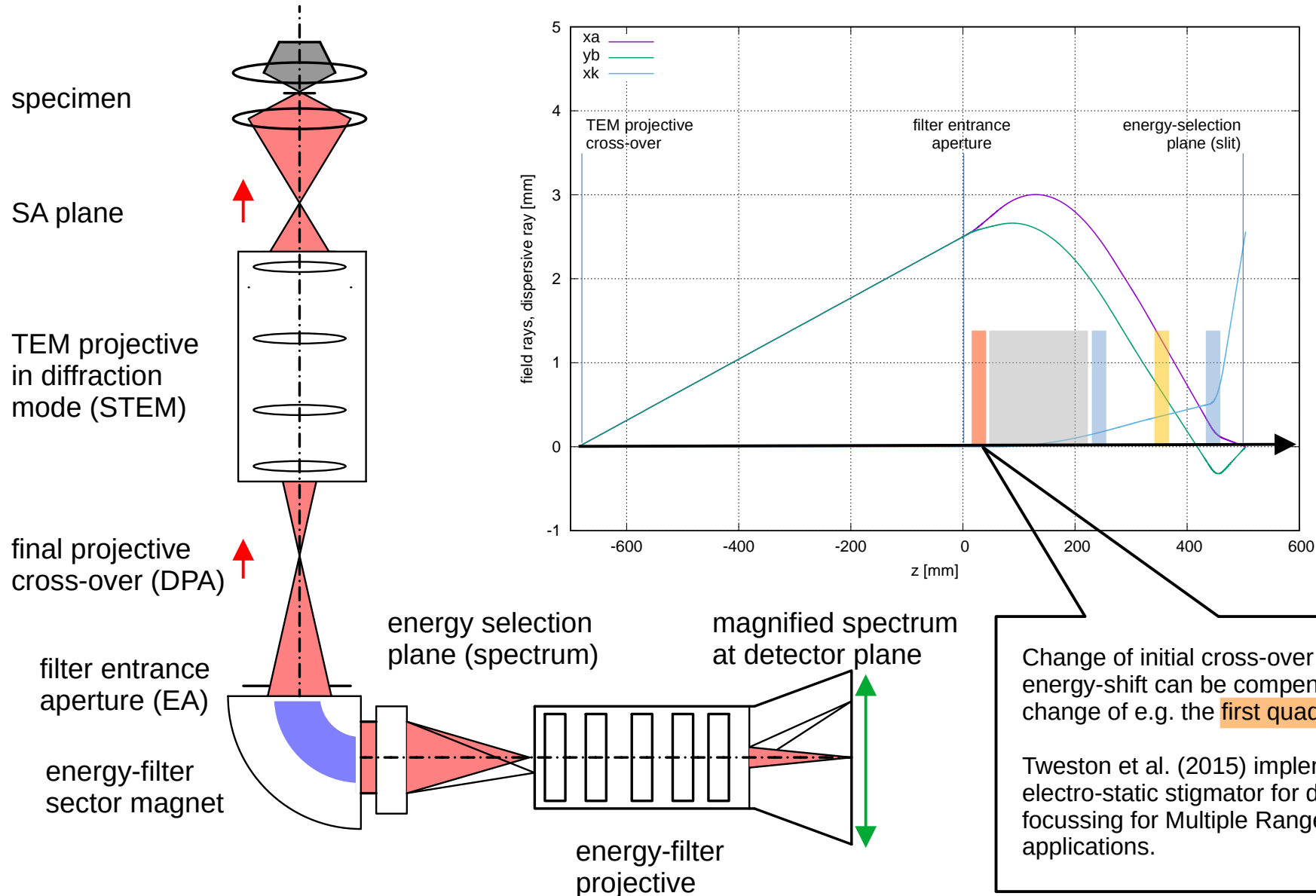
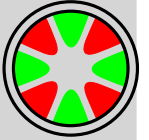
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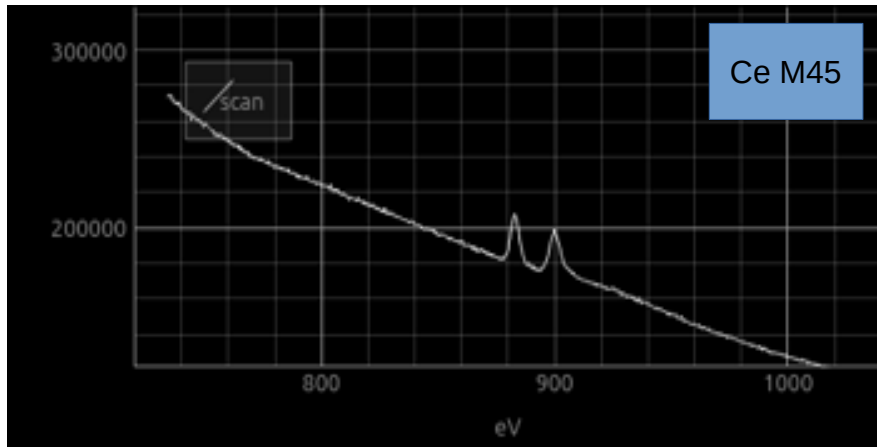
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- change LT (fast, dynamic EELS)

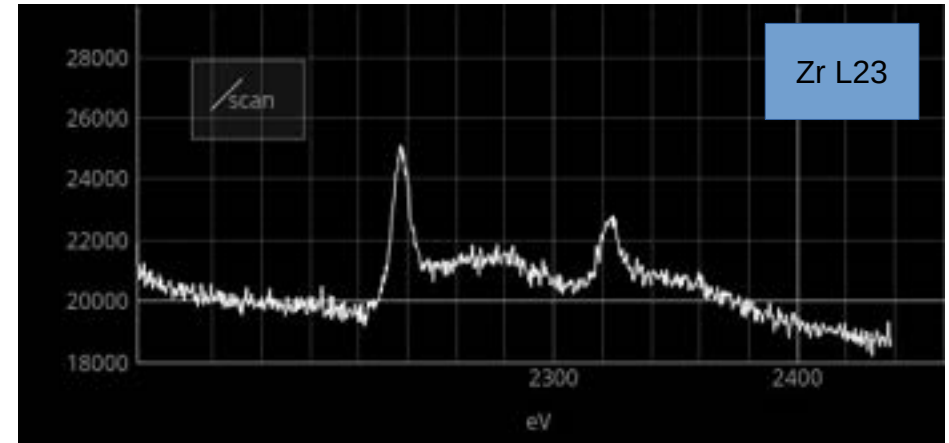
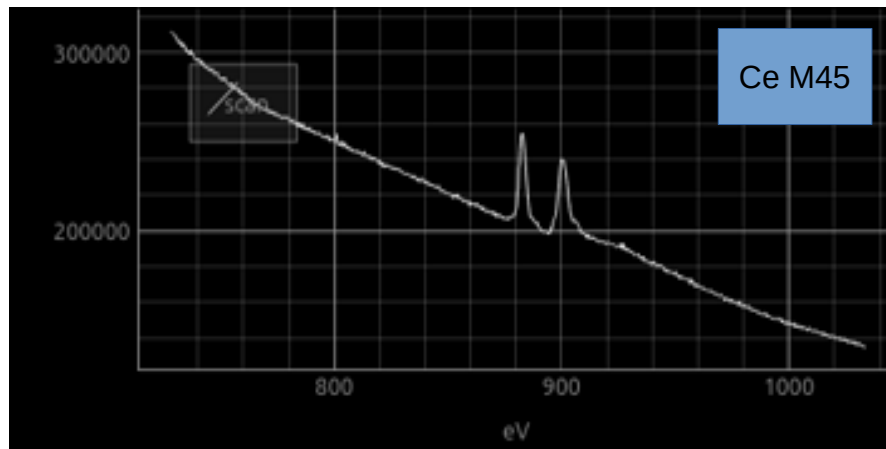
Dynamic EELS:

- switch low-loss and core-loss
- synchronize with STEM scan

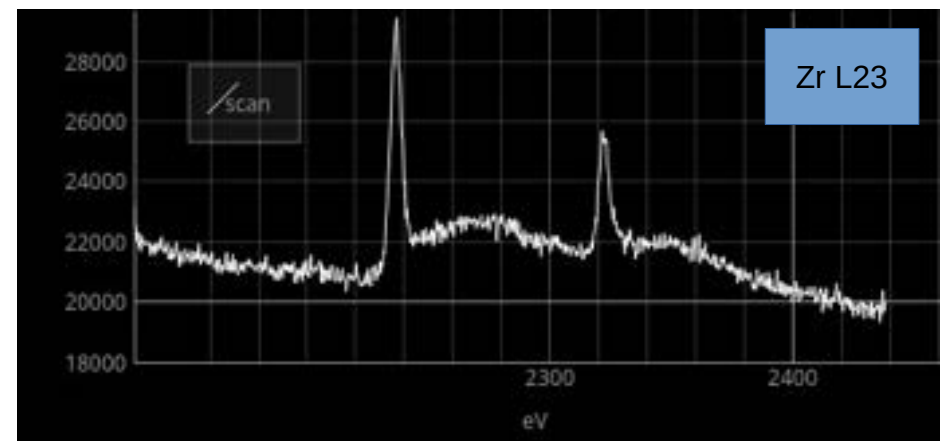


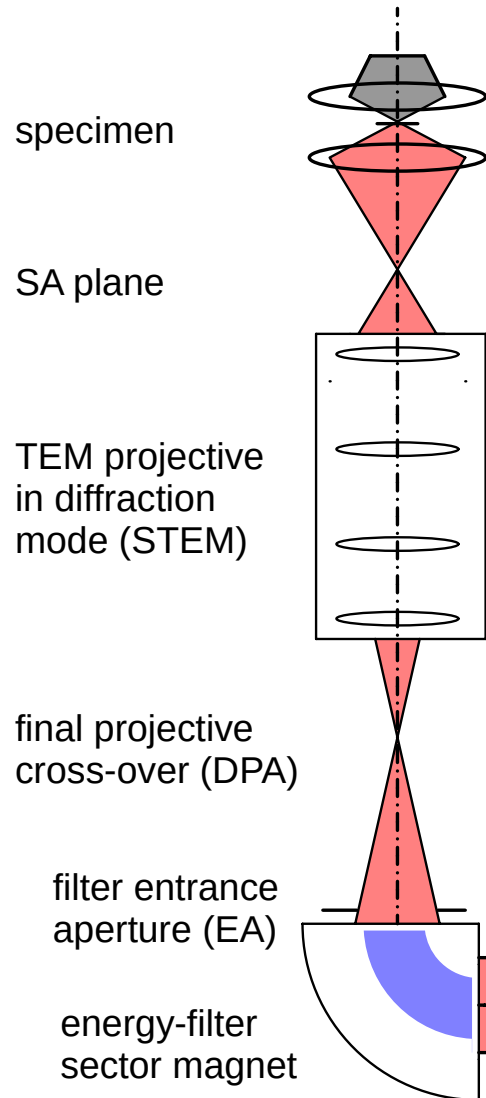
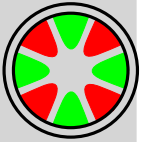


MP1-2y
+1mA

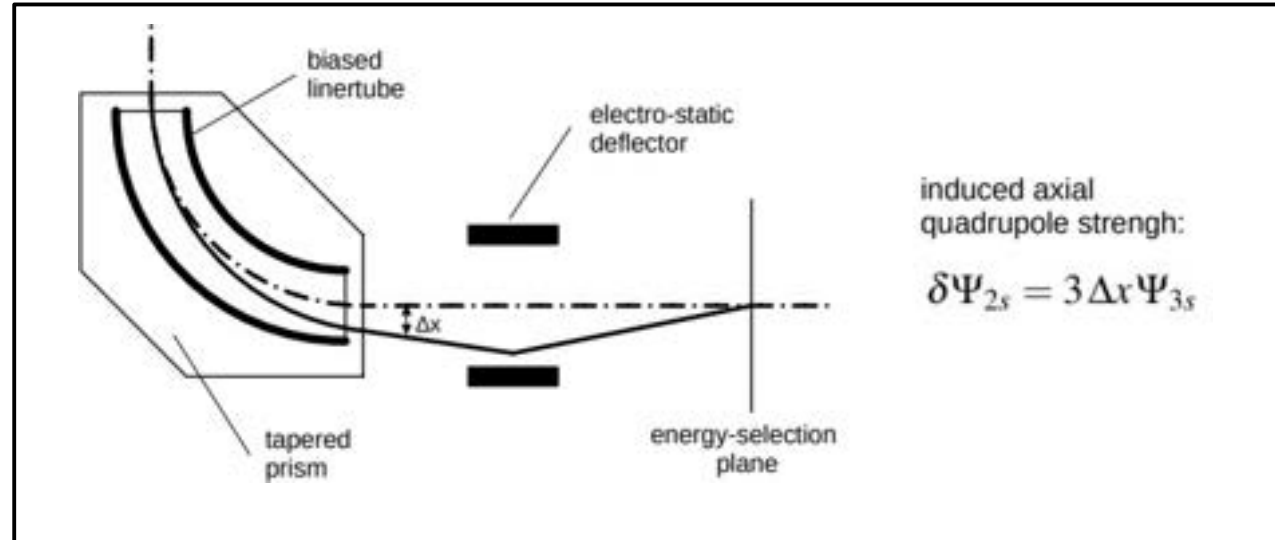


MP1-2y
+2.5mA

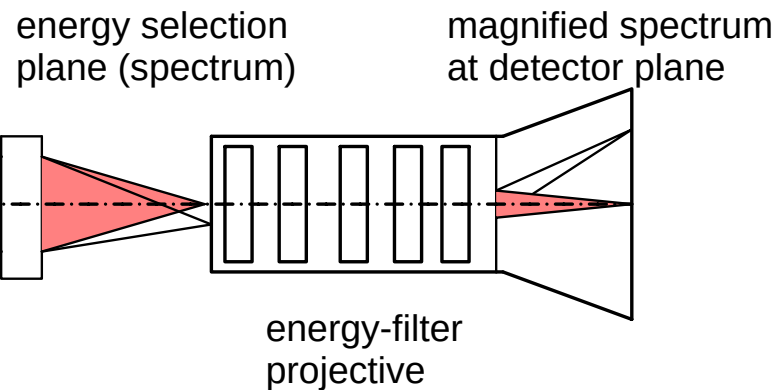




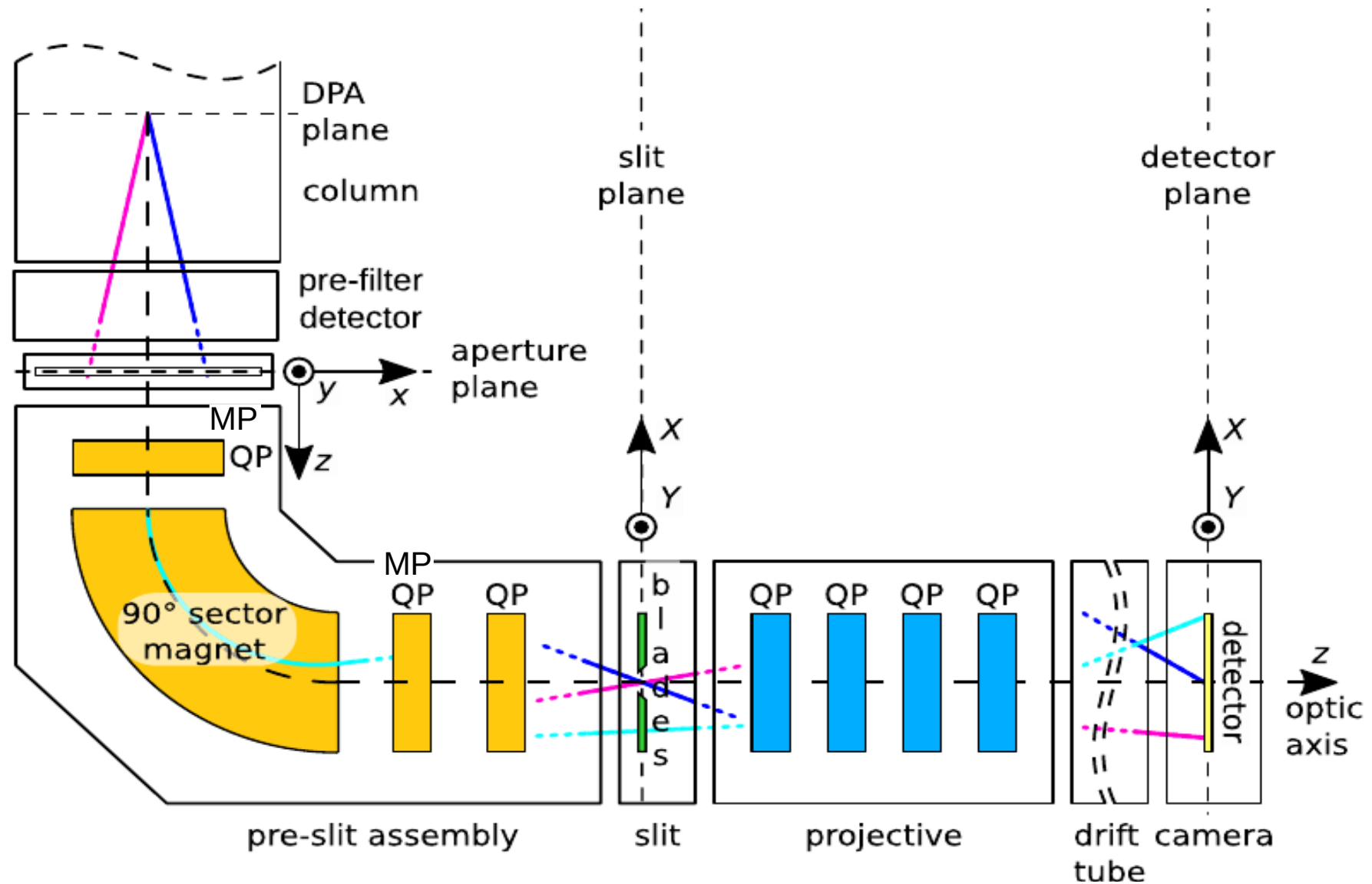
Other possibility for dynamic re-focussing w/o stigmator



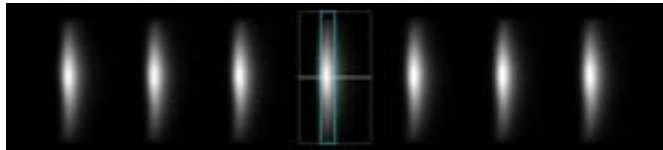
Poster: IM1.P01 Mo. 14:00-16:00



EELS Alignment



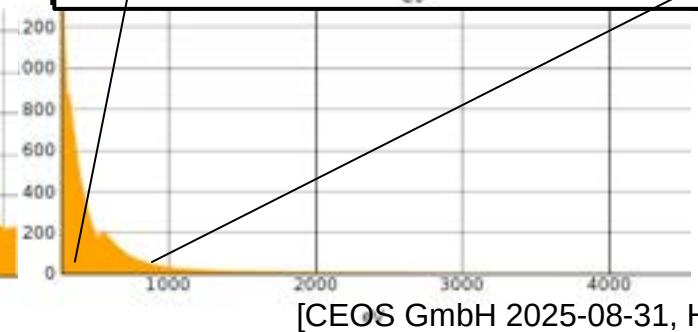
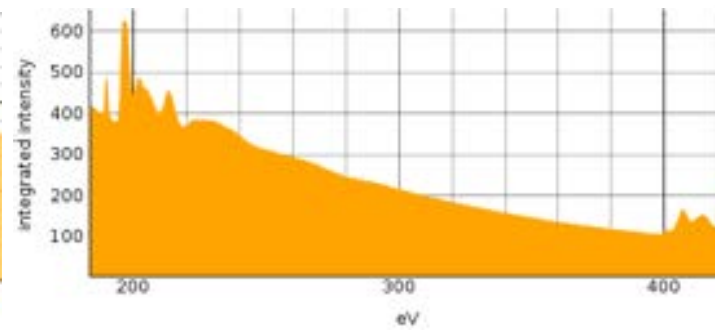
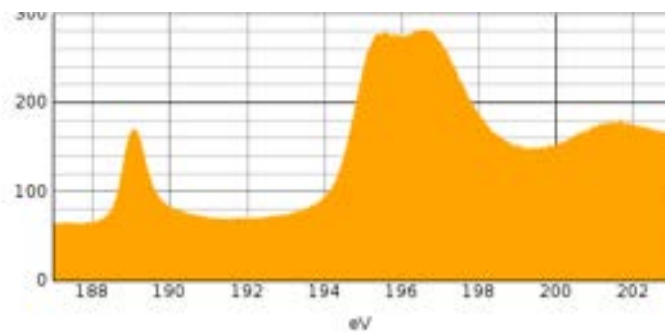
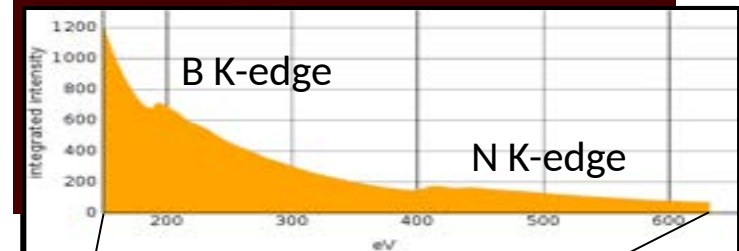
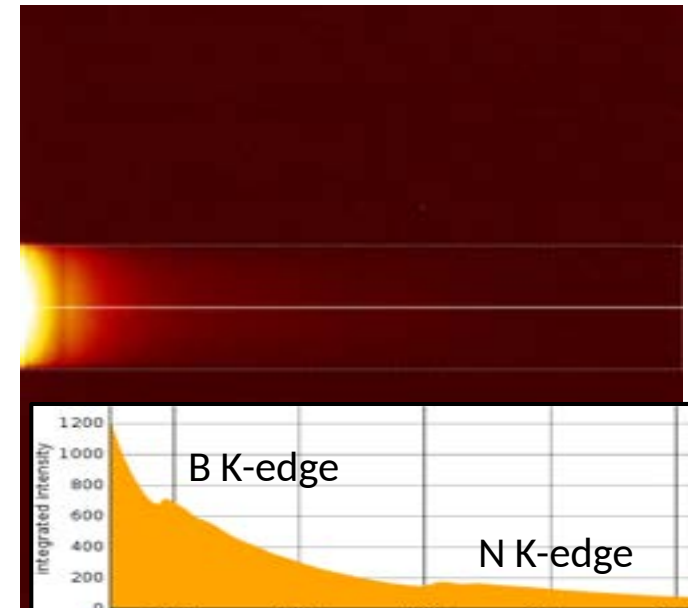
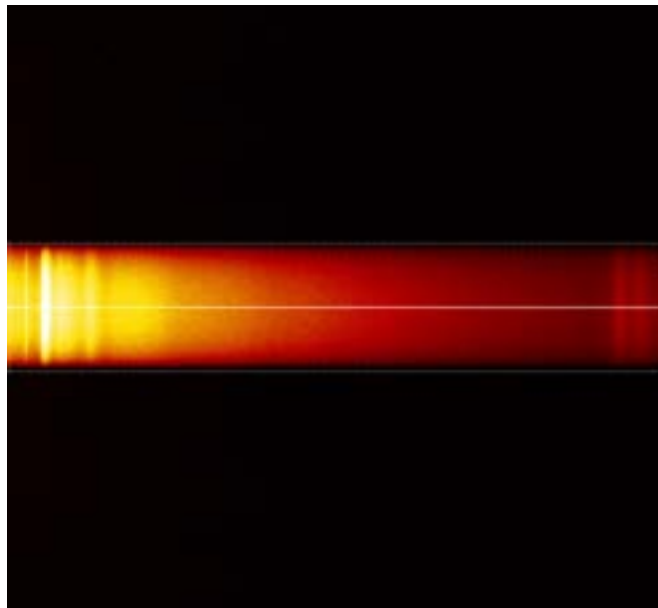
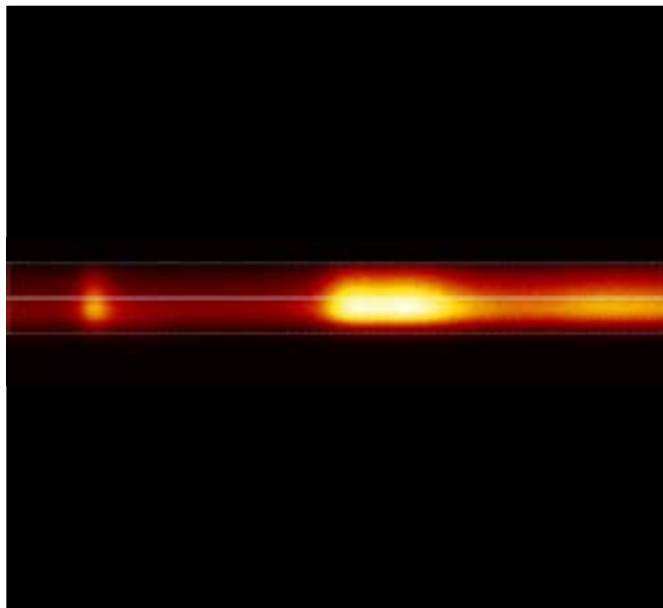
16 eV range, 7.8 meV/pix



256 eV range, 125 meV/pix

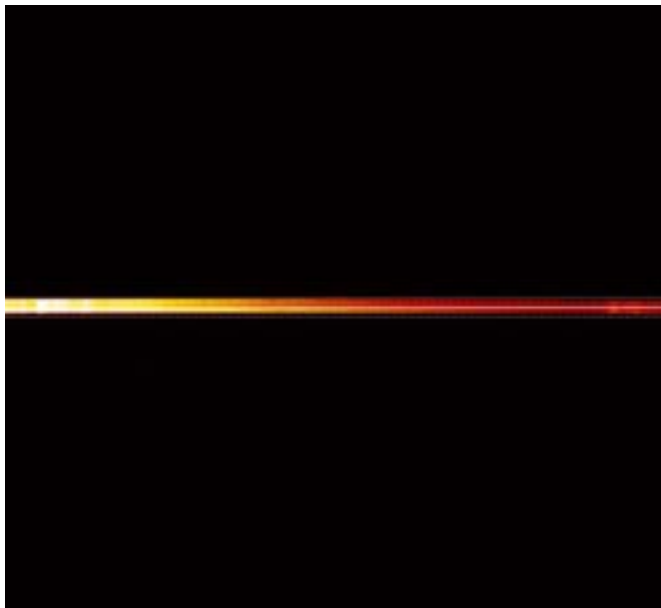


4 keV range, 2 eV/pix

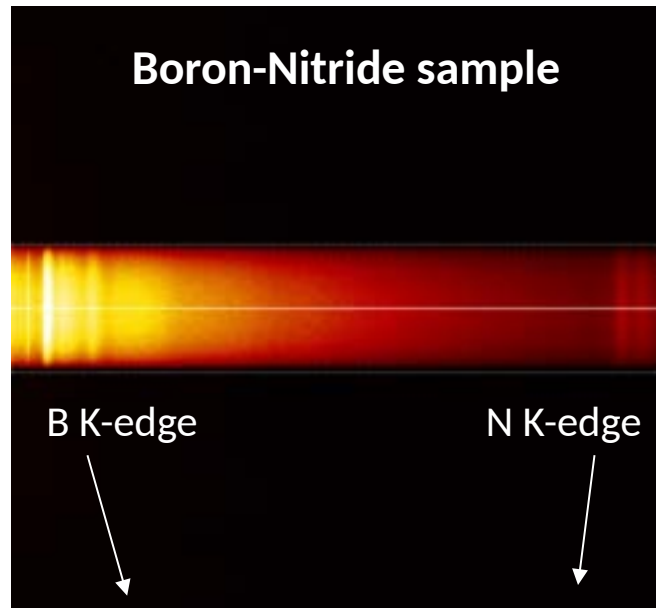


Adjustable spectrum height:

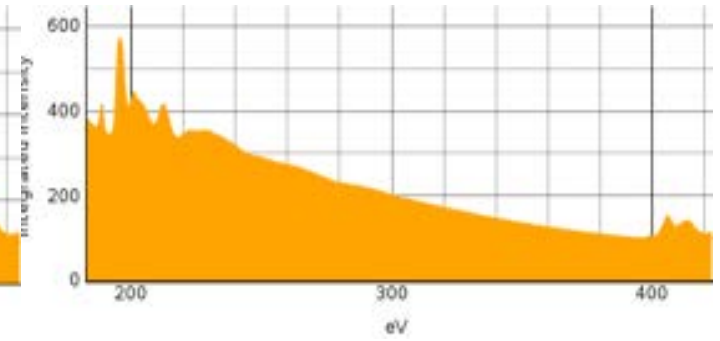
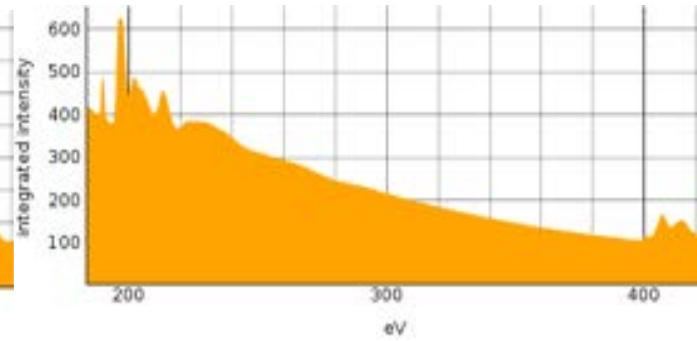
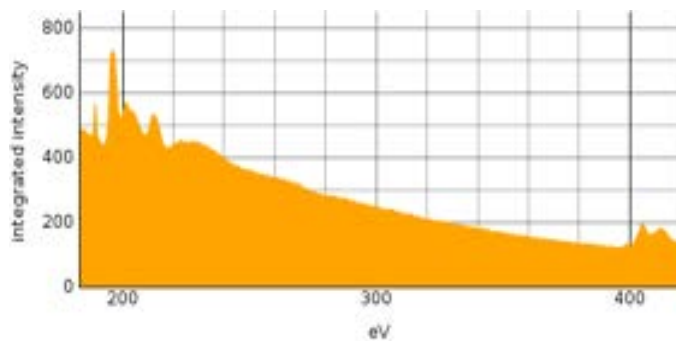
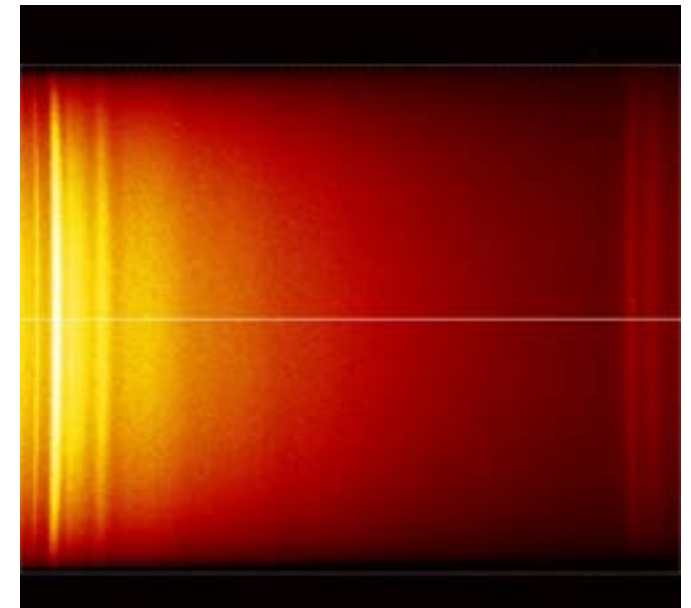
50 pix (2.5% of detector)



400 pix (20% of detector)



1800 pix (90% of detector)



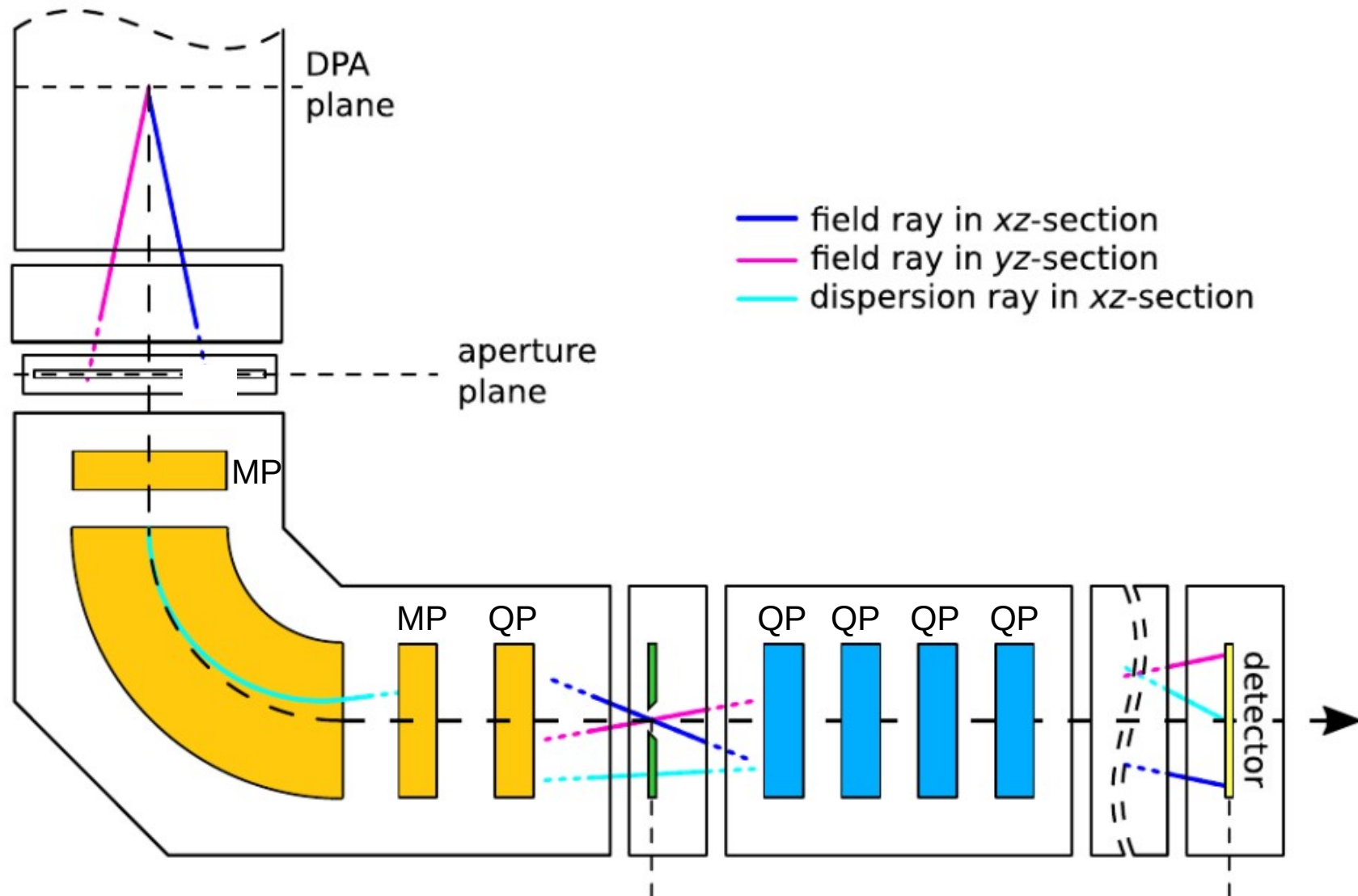
EELS: Three degrees of freedom (Quadrupoles)

- * Dispersion at detector (EELS magnification)
- * Spectrum height (defocus in y-direction)
- * Spectrum focus (SX10)

Momentum resolved EELS:

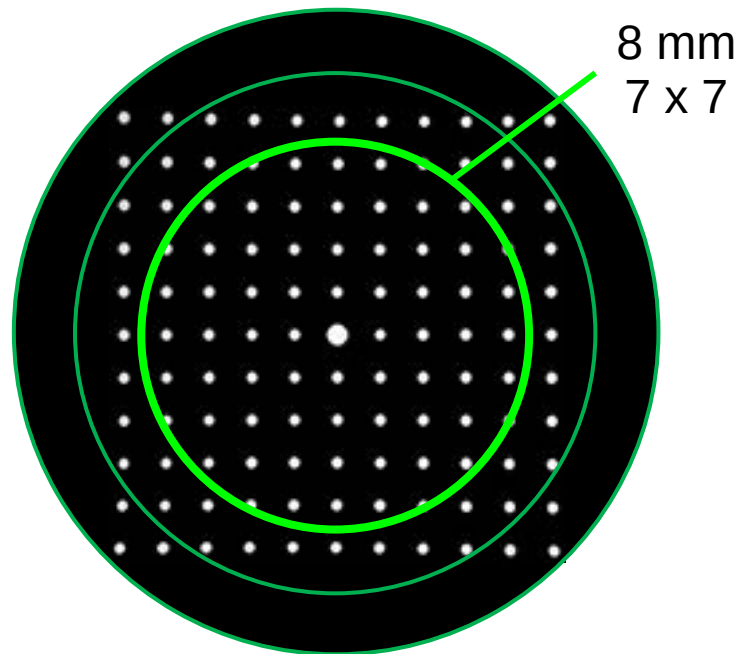
- * focus entrance aperture at detector in y-direction
 - x: Energy coordinate (dispersion scale)
 - y: conjugated to entrance aperture (e.g. momentum in y-direction)
- * momentum space in projected (averaged) in x-direction and resolved in y-direction
 - => *use slit-shaped aperture to confine momentum in x-direction*

ESI Alignment

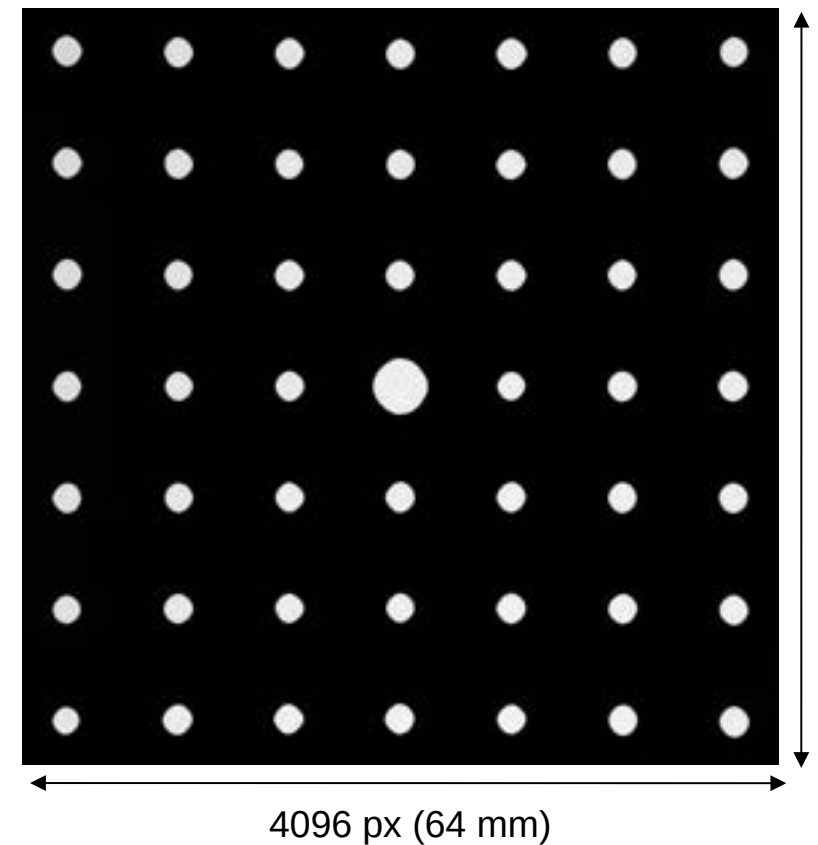


Flexible post-magnification

alignment mask in entrance aperture

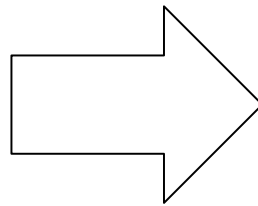
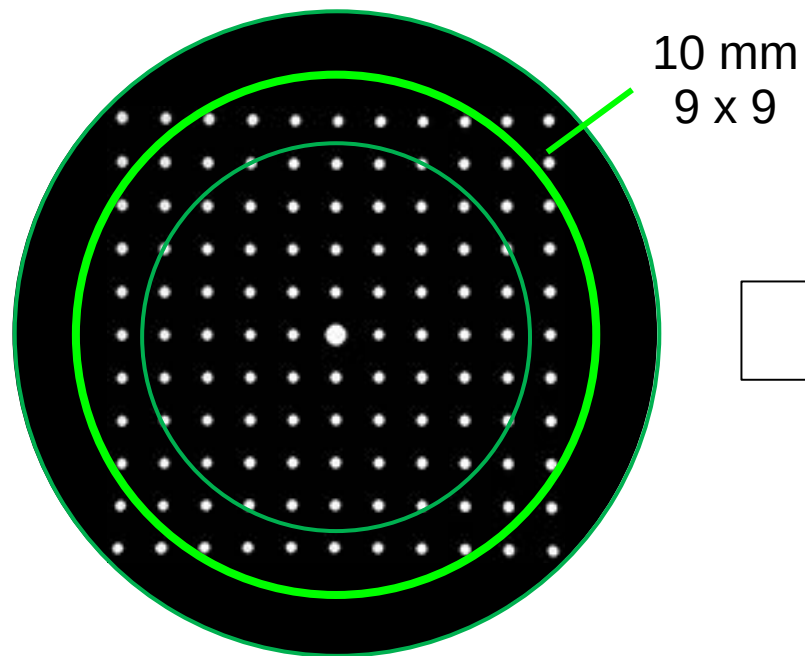


detector (TVIPS XF416)

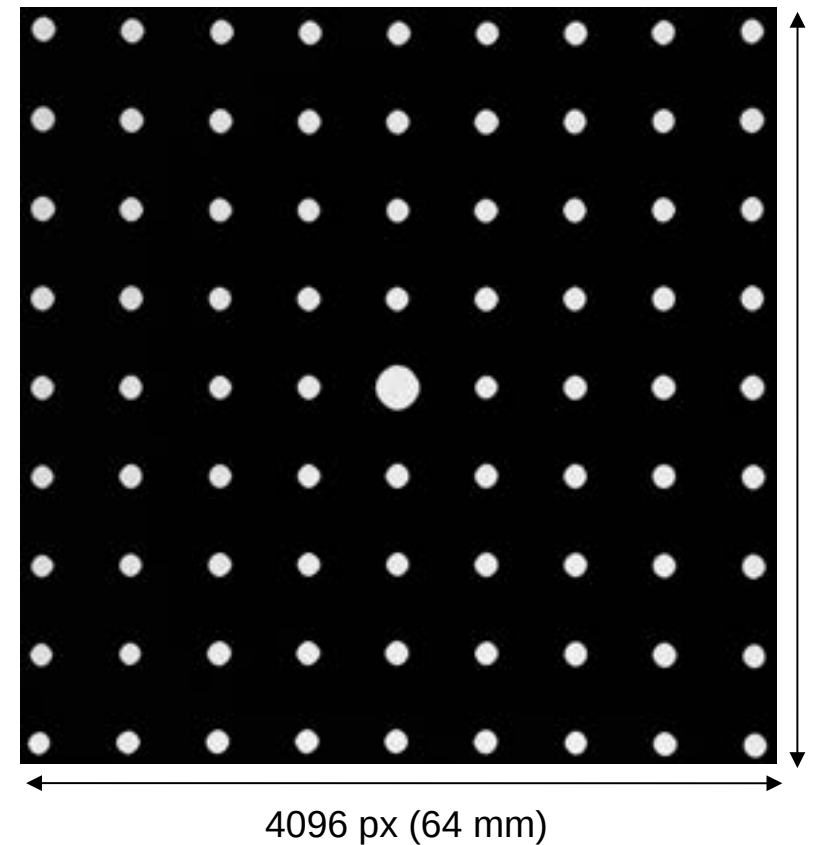


Flexible post-magnification

alignment mask in entrance aperture

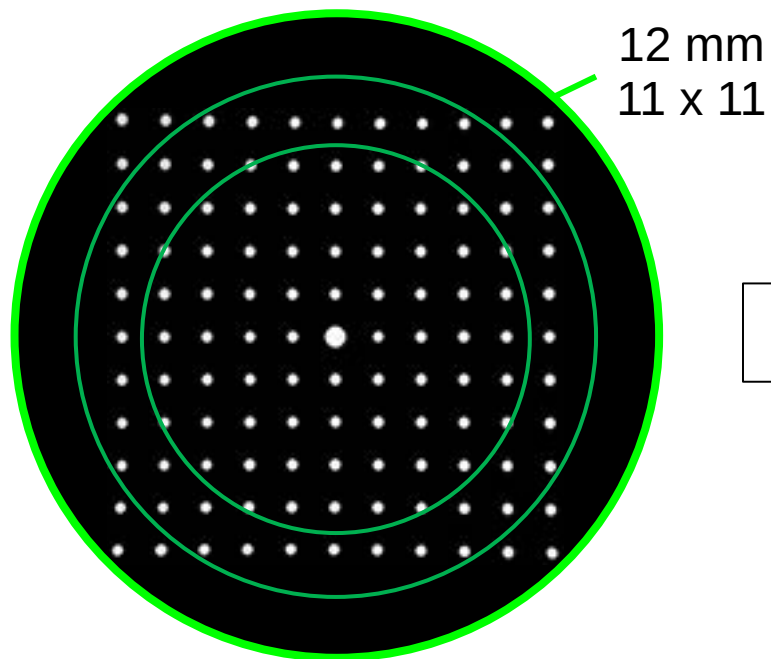


detector (TVIPS XF416)

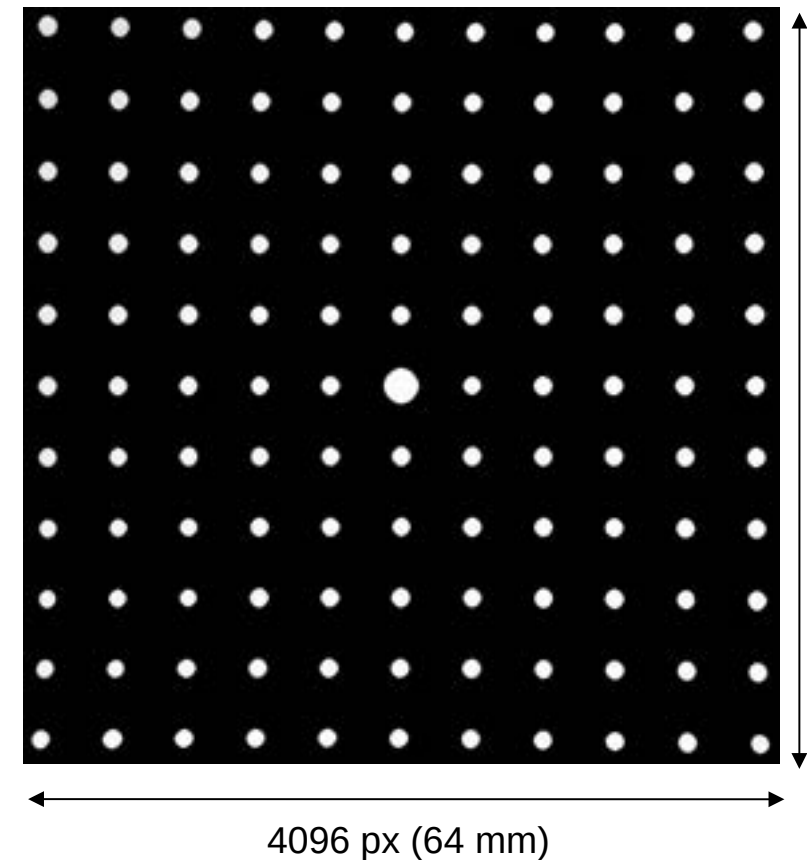


Flexible post-magnification

alignment mask in entrance aperture

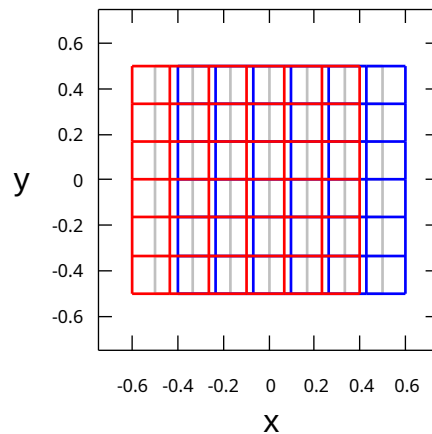


detector (TVIPS XF416)

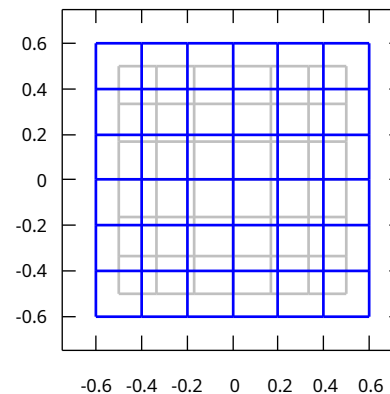


ESI: Correction of Dispersion and Distortions

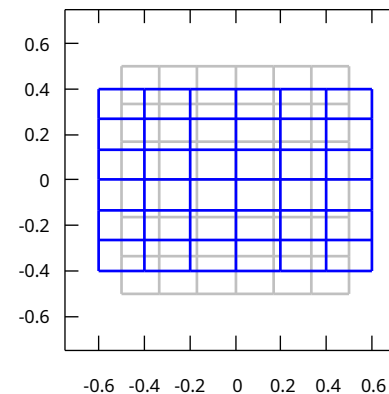
CX001



Magnification



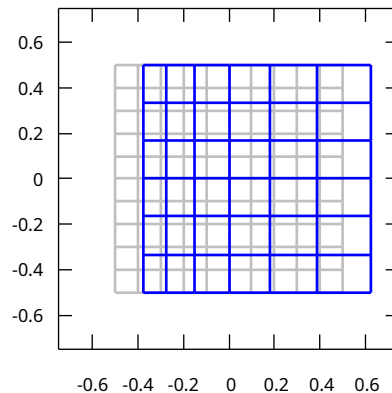
Aspect



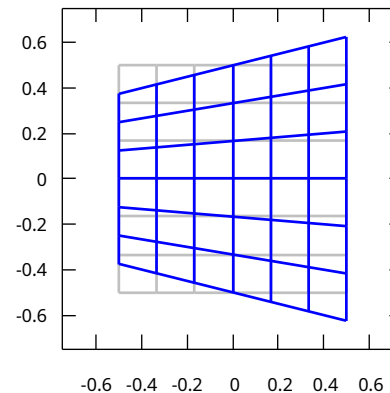
Three
first-rank
degrees of
freedom

“Quadruples”

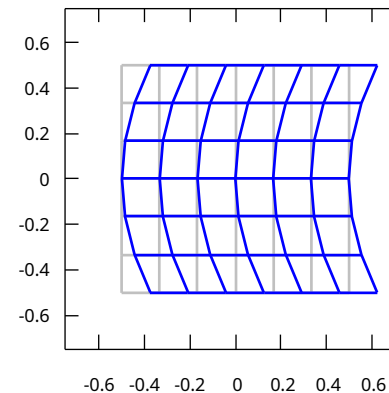
DX20



DY11



DX02



Three
second-order
degrees of
freedom

“Hexapoles”

Non-Linear Mapping of Entrance aperture onto Detector:

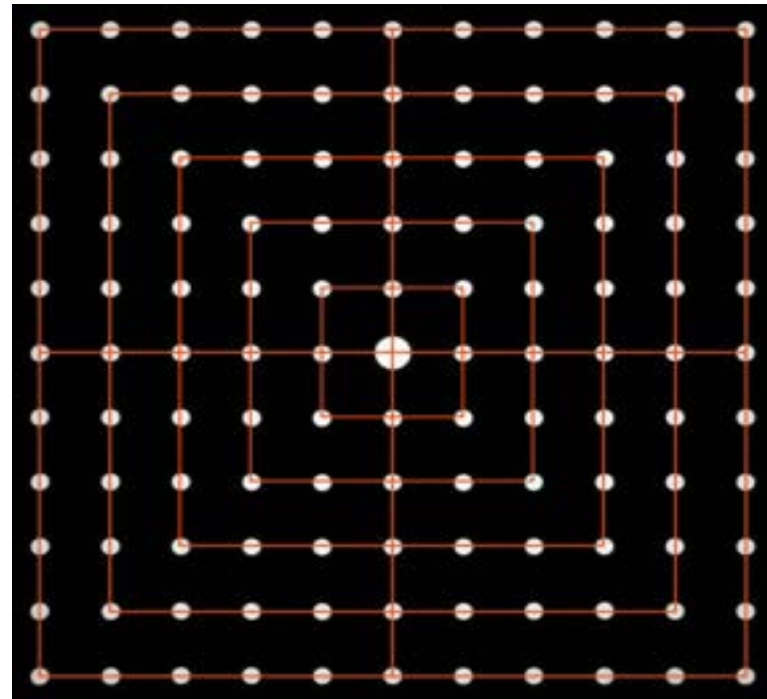
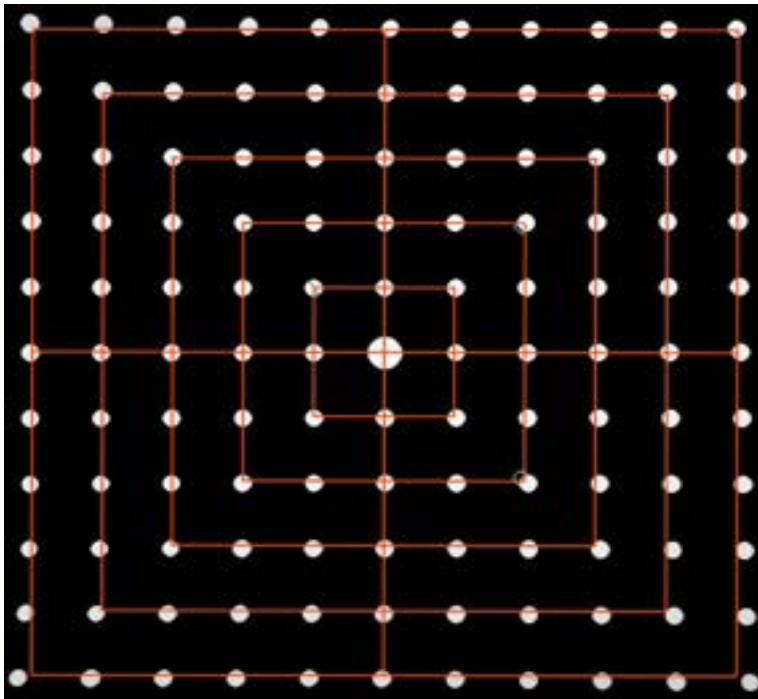
$$\begin{pmatrix} X \\ Y \end{pmatrix} = \begin{pmatrix} X_{00} \\ Y_{00} \end{pmatrix} + \begin{pmatrix} X_{10} & X_{01} \\ Y_{10} & Y_{01} \end{pmatrix} \begin{pmatrix} x \\ y \end{pmatrix} + \begin{pmatrix} X_{001} \\ Y_{001} \end{pmatrix} \Delta E + \begin{pmatrix} \Delta X(x, y, \Delta E) \\ \Delta Y(x, y, \Delta E) \end{pmatrix} \quad (2)$$

with the non-linear term

$$\begin{pmatrix} \Delta X \\ \Delta Y \end{pmatrix} = \sum_{R>1} \sum_{k=0}^R \sum_{\substack{m=0 \\ n=R-k-m}}^{R-k} \begin{pmatrix} X_{nmk} \\ Y_{nmk} \end{pmatrix} x^n y^m \Delta E^k. \quad (3)$$

Dewarping

$$\vec{R}_{ij} = \sum_{r=0}^R d_m^r \sum_{\substack{m=0 \\ n=r-m}}^r \begin{pmatrix} X_{nm} \\ Y_{nm} \end{pmatrix} i^n j^m$$



Summary of Alignment Strategy:

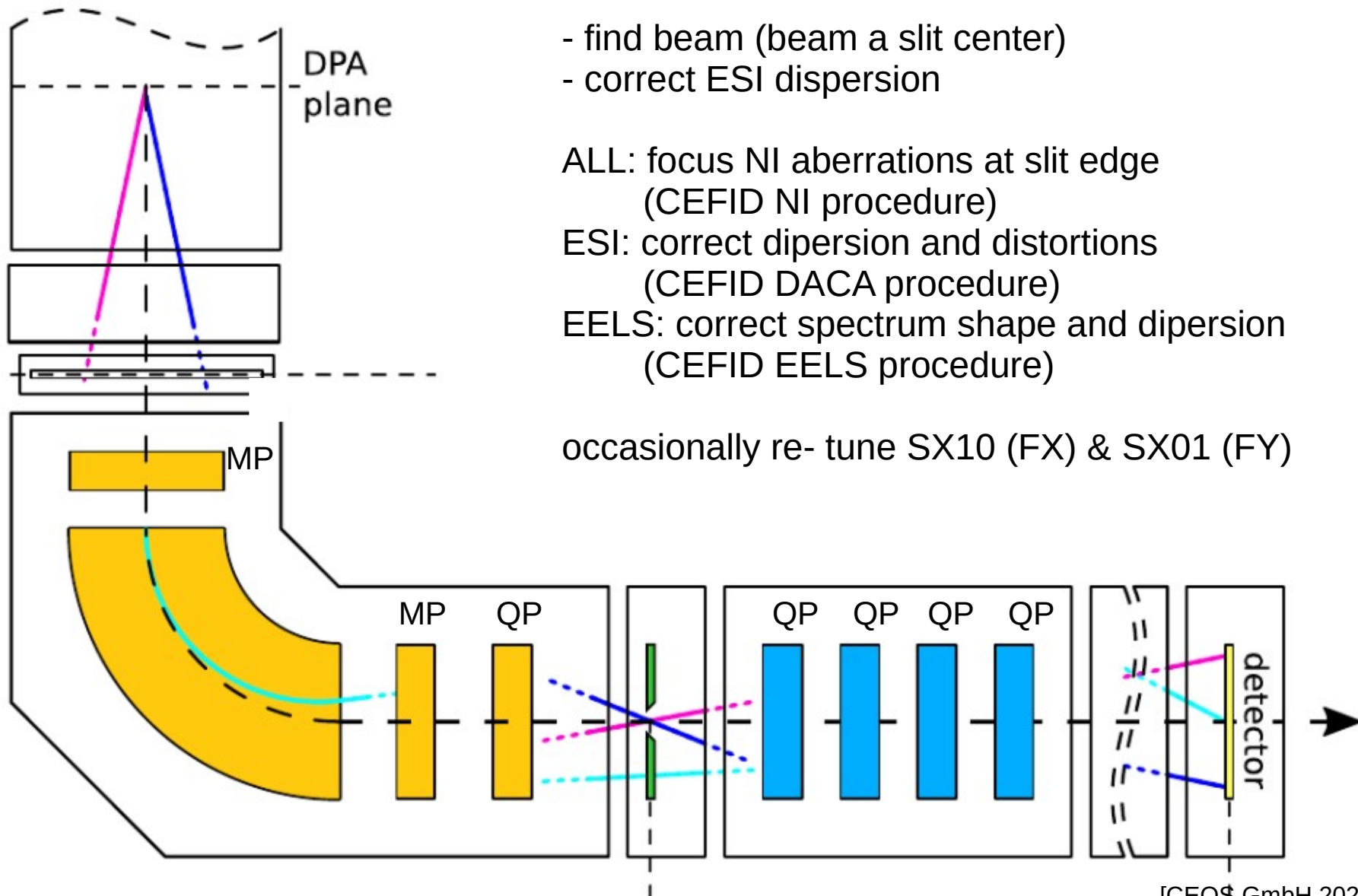
- find beam (beam a slit center)
- correct ESI dispersion

ALL: focus NI aberrations at slit edge
(CEFID NI procedure)

ESI: correct dispersion and distortions
(CEFID DACA procedure)

EELS: correct spectrum shape and dispersion
(CEFID EELS procedure)

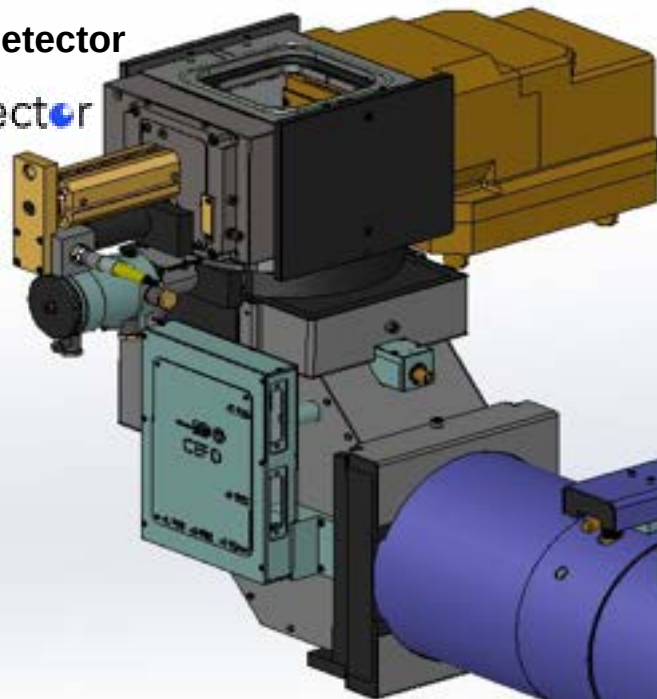
occasionally re- tune SX10 (FX) & SX01 (FY)



CEOS Energy-Filter and Imaging Device (CEFID)

e.g. ADF Detector

PN Detector



Direct Electron

e.g. DE Apollo

Efforts spend by CEOS:

- state-of-the-art optics
- simple semi-automatic alignment
- stable and reproducible settings
- flexible detector interfaces
- open interfaces (interoperability)
- open-source software platform (except for some device interfaces)

e.g. Merlin EM



e.g. CheeTah EM



TVIPS
TIEZT VIDEO AND IMAGE PROCESSING SYSTEMS

e.g. XF416R

DECTRIS
detecting the future

e.g. ELA